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(12) **United States Patent**
Furuta et al.

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(45) **Date of Patent:** **Apr. 10, 2012**

(54) **METHOD FOR MANUFACTURING PRINTED WIRING BOARD AND PRINTED WIRING BOARD**

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(73) Assignee: **Ibiden Co., Ltd.**, Ogaki-shi (JP)

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 200 days.

(21) Appl. No.: **12/685,716**

(22) Filed: **Jan. 12, 2010**

(65) **Prior Publication Data**

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Related U.S. Application Data

(60) Provisional application No. 61/156,122, filed on Feb. 27, 2009.

(51) **Int. Cl.**
H05K 1/11 (2006.01)
H05K 3/10 (2006.01)

(52) **U.S. Cl.** **174/261**; 174/250; 29/825; 29/829; 29/846

(58) **Field of Classification Search** 174/250, 174/255, 260, 261; 29/825, 829, 831-832, 29/846; 361/760

See application file for complete search history.

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(74) *Attorney, Agent, or Firm* — Oblon, Spivak, McClelland, Maier & Neustadt, L.L.P.

(57) **ABSTRACT**

A method for manufacturing a printed wiring board includes forming a metal film on a surface of an insulative board, a plating resist on the metal film, and a plated-metal film on the metal film exposed from the plating resist, covering a portion of the plated-metal film with an etching resist, etching to reduce thickness of the plated-metal film exposed from the etching resist, removing the resists, and forming a wiring having a pad and a conductive circuit thinner than the pad by removing the metal film exposed through the removing of the plating resist, a solder-resist layer on the surface of the board and wiring, in the layer an opening exposing the pad and a portion of the circuit contiguous to the pad, a solder film on the pad and portion of the circuit exposed through the opening, and a solder bump on the pad by solder reflow.

20 Claims, 20 Drawing Sheets

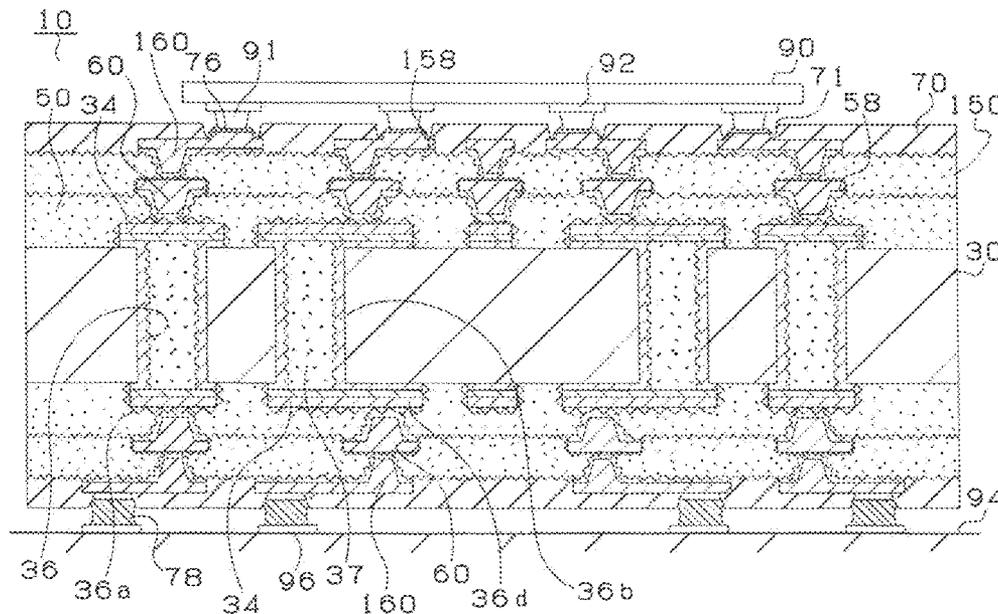


FIG. 1(A)

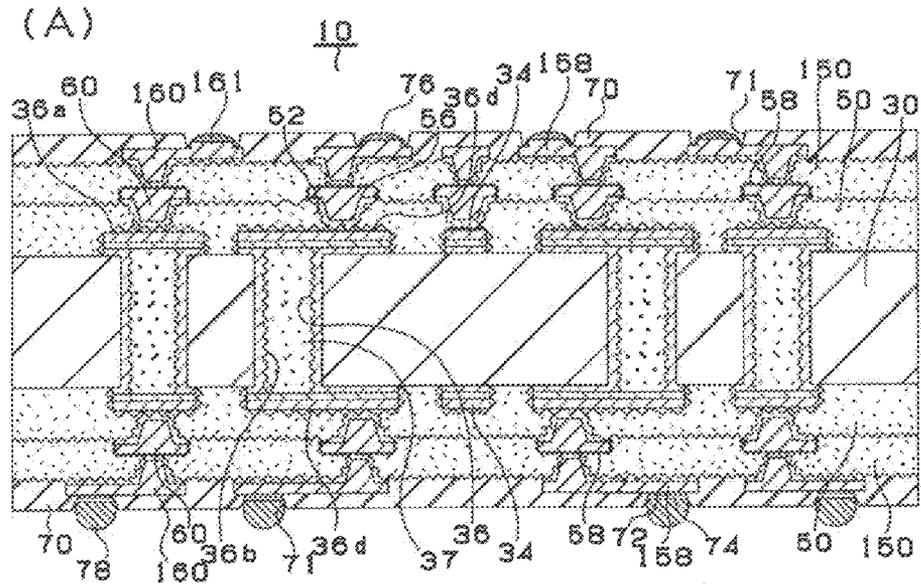


FIG. 1(B)

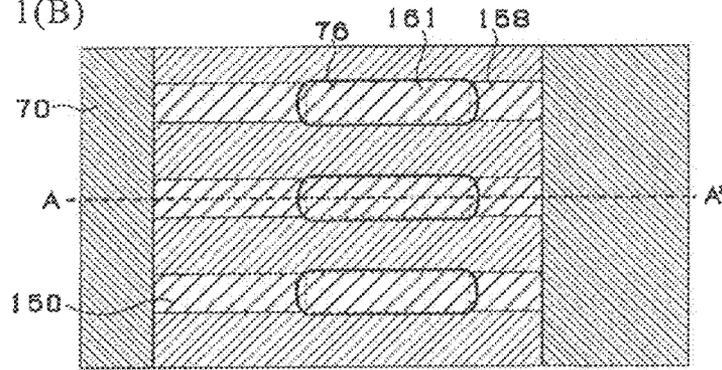


FIG. 1(C)

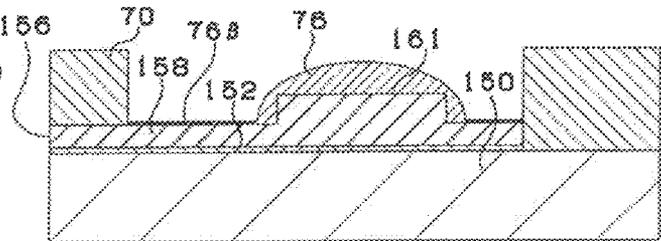


FIG. 1(D)

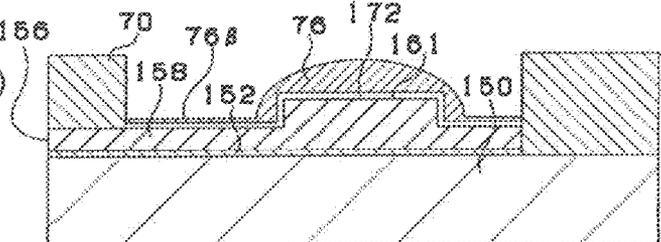


FIG. 2(A)



FIG. 2(B)

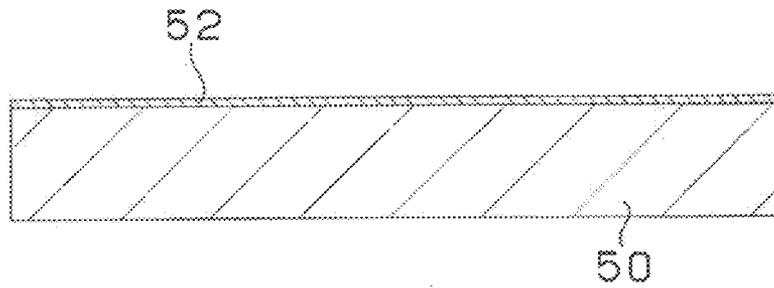


FIG. 2(C)

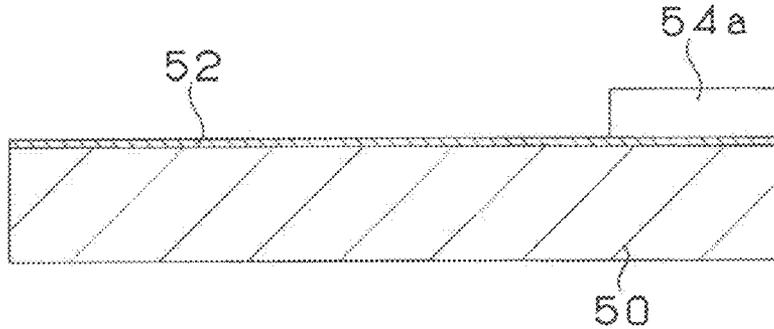
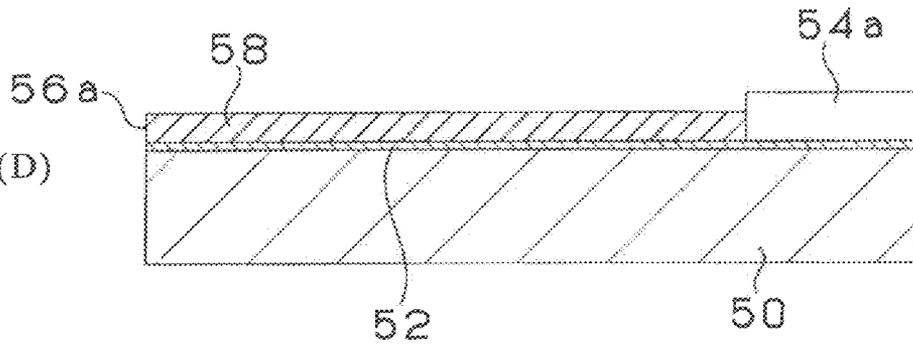
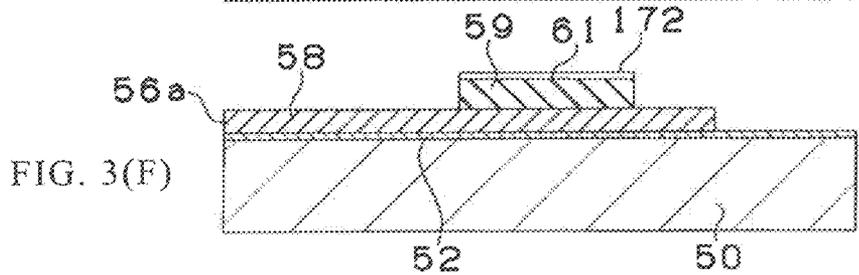
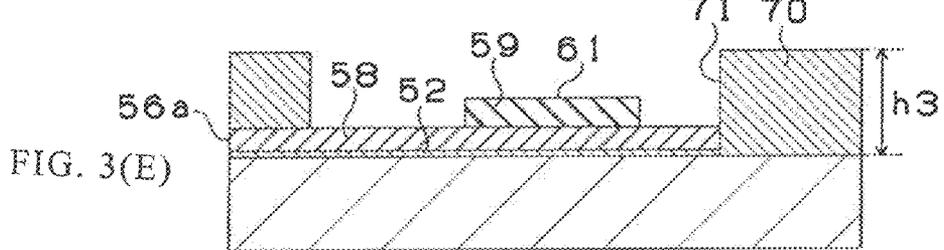
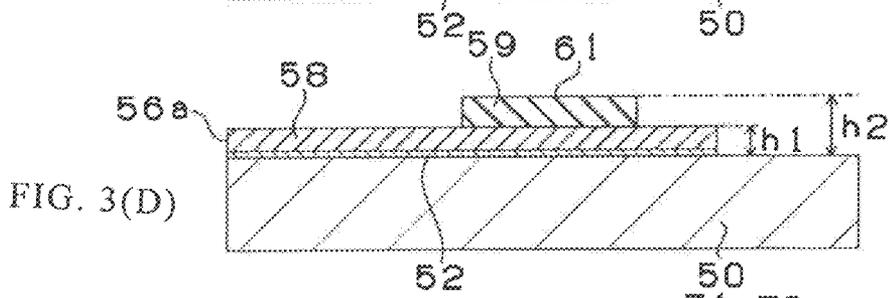
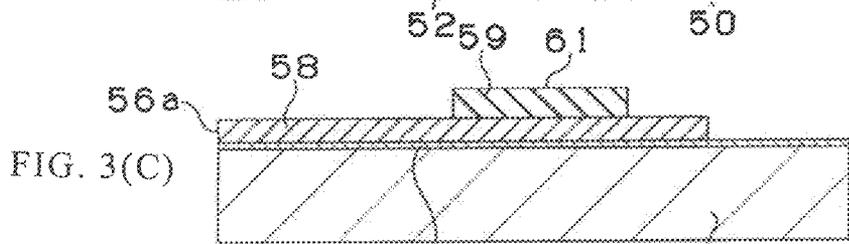
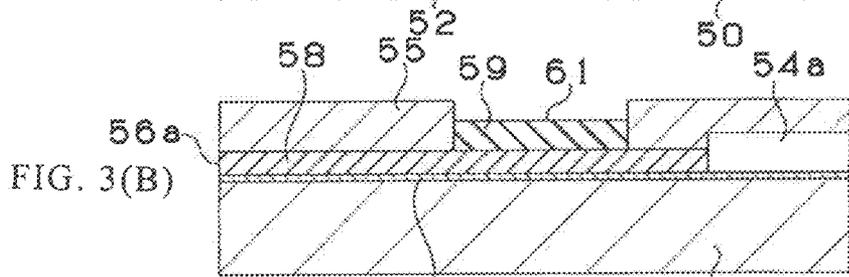
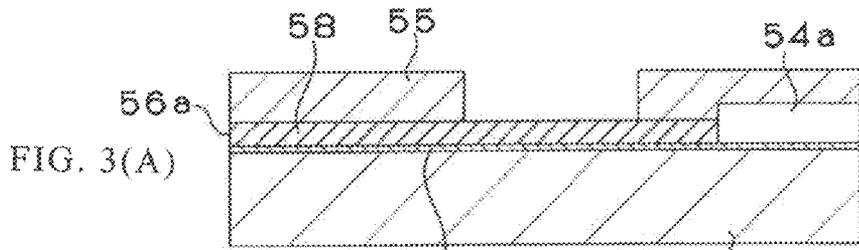


FIG. 2(D)





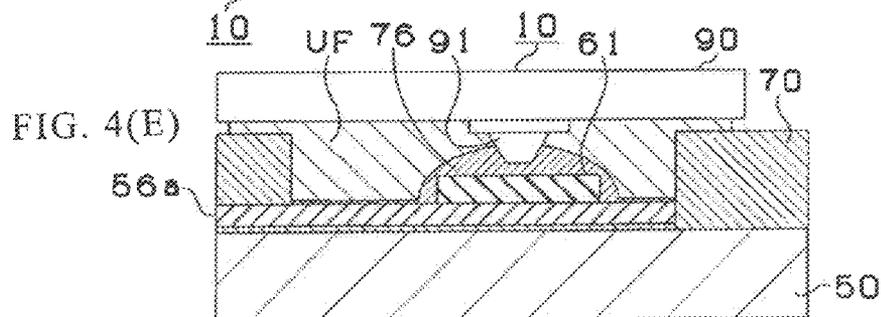
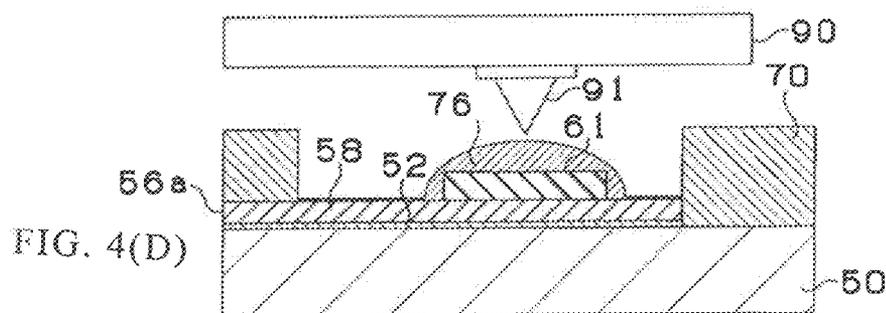
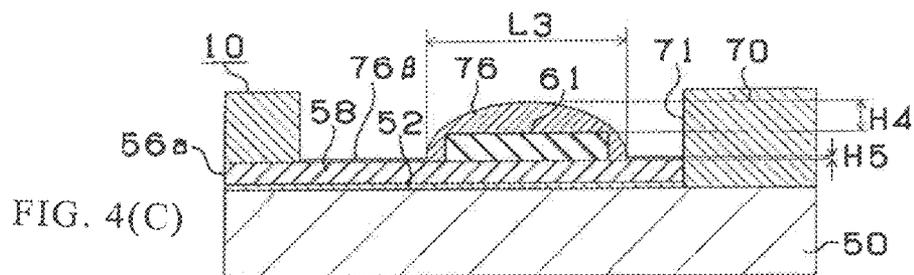
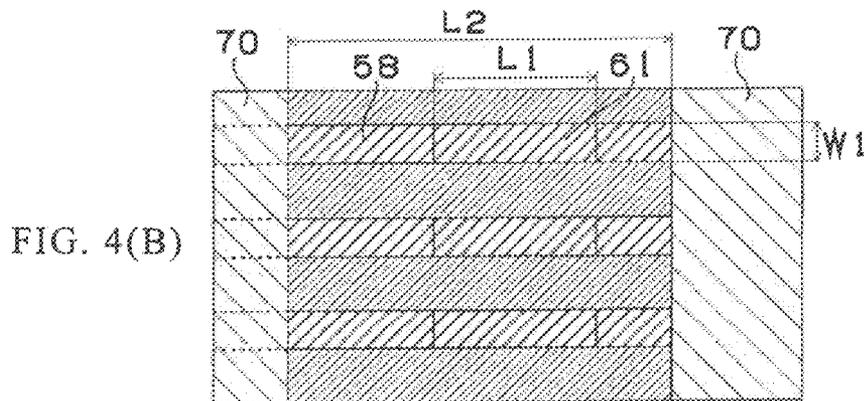
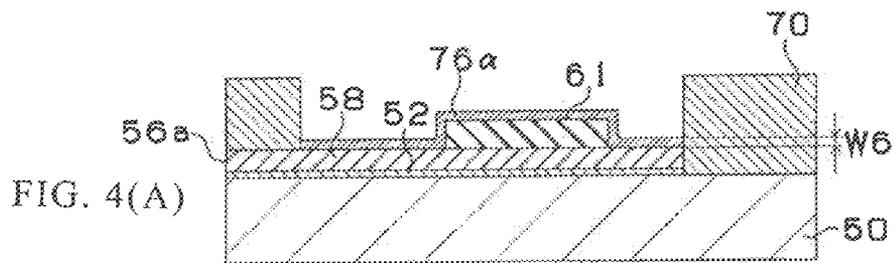


FIG. 5(A)

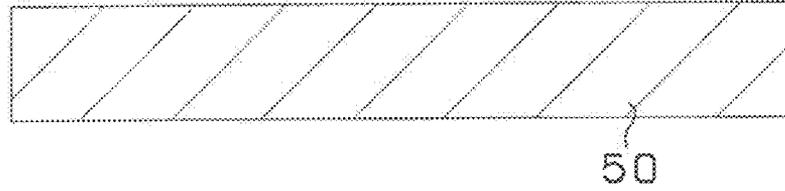


FIG. 5(B)

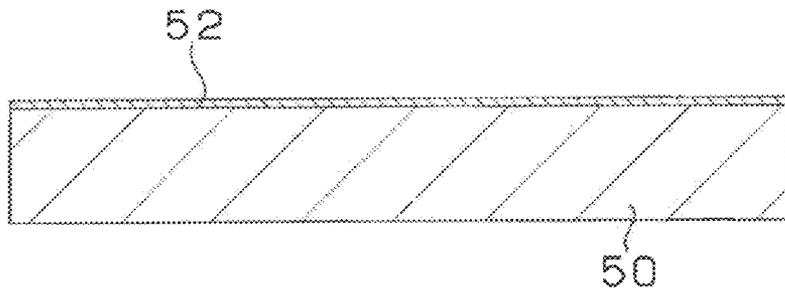


FIG. 5(C)

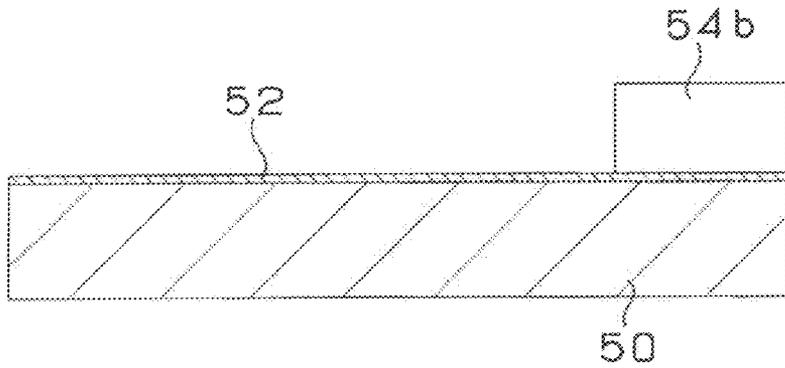
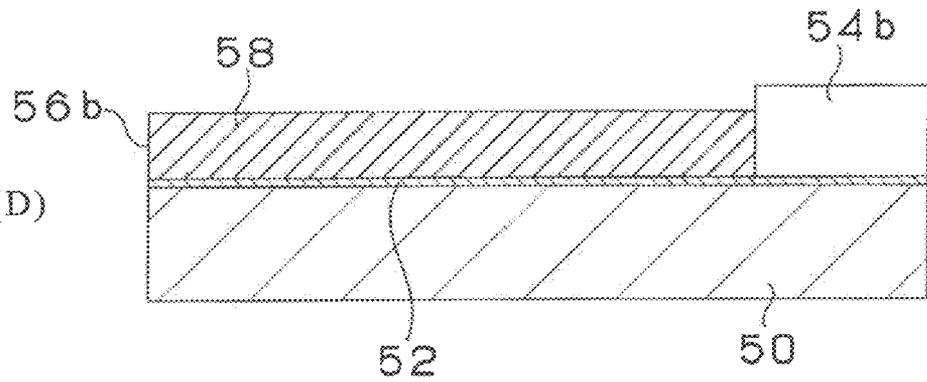
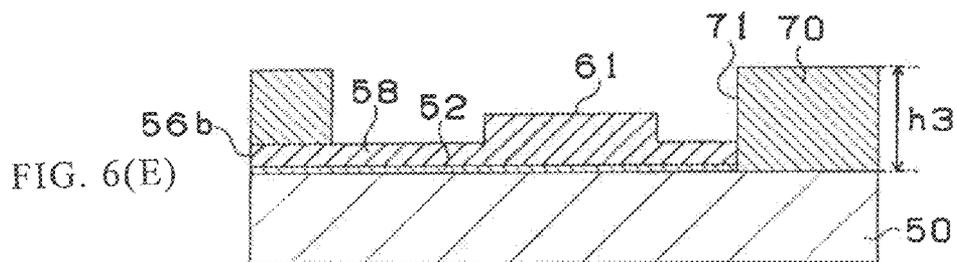
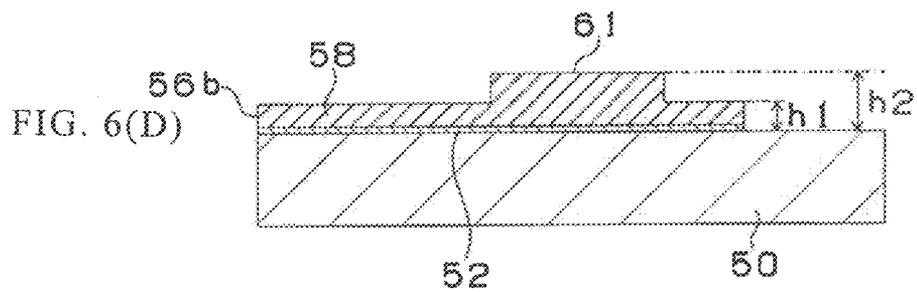
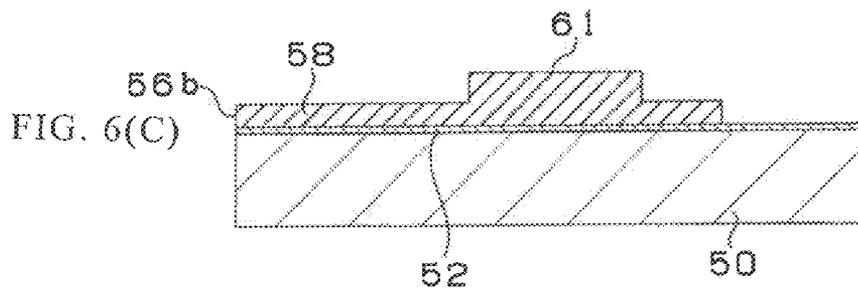
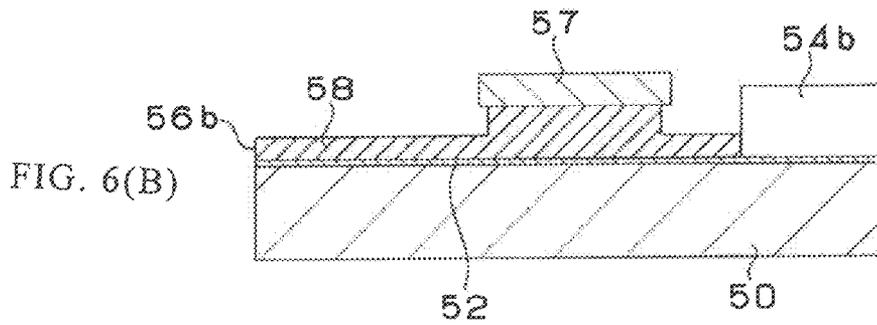
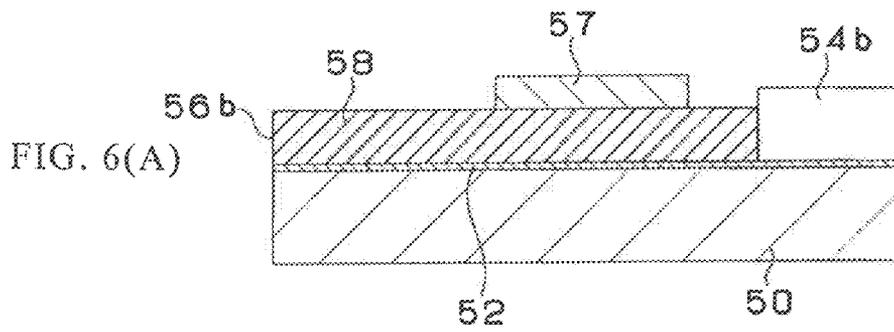
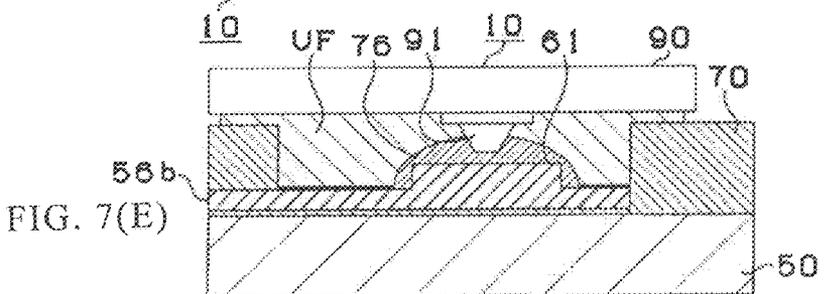
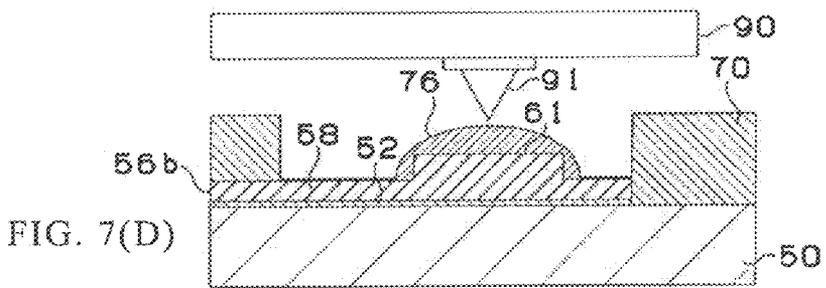
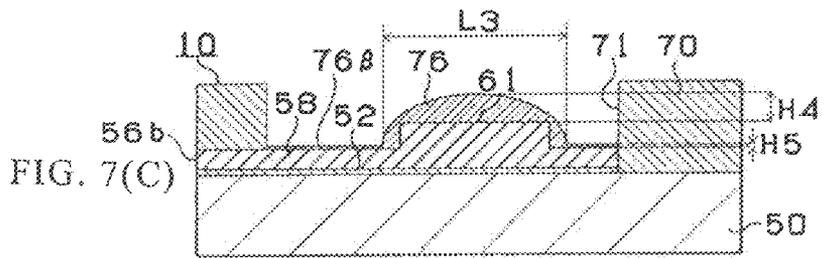
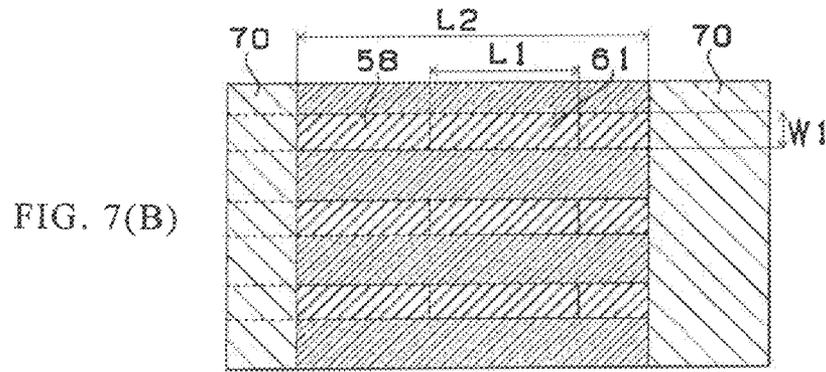
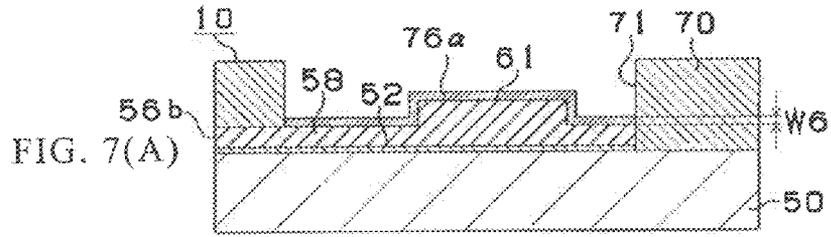
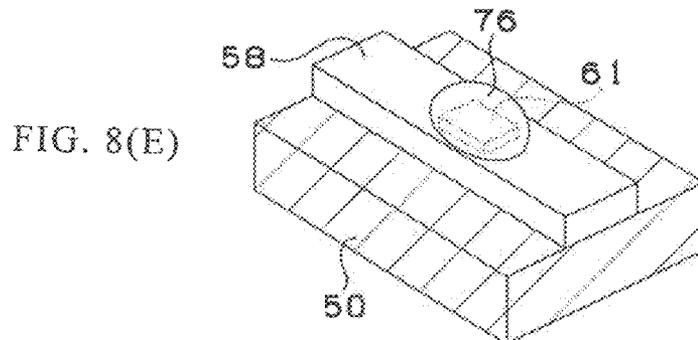
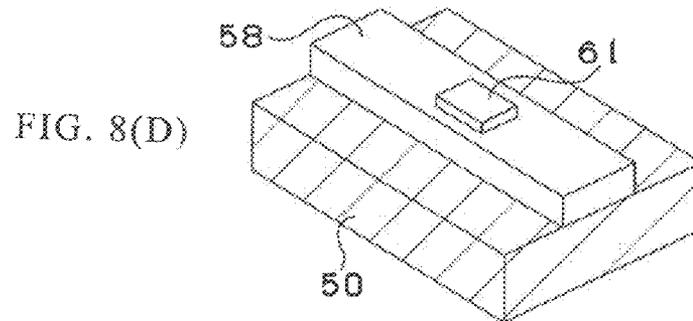
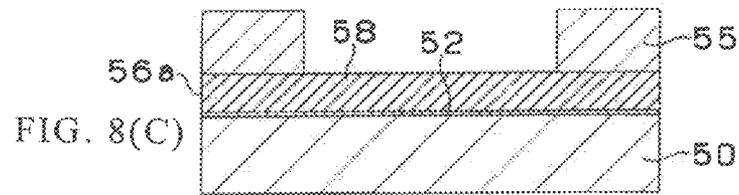
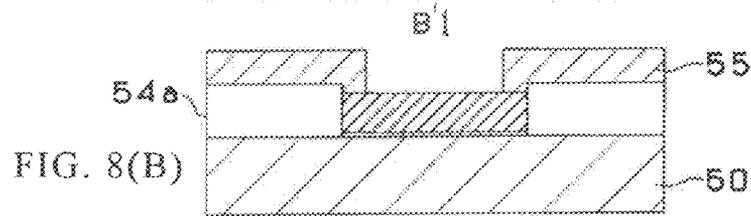
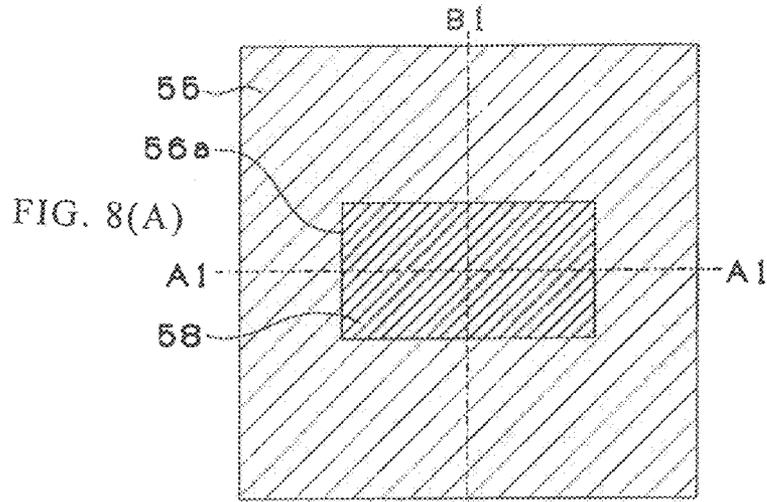


FIG. 5(D)









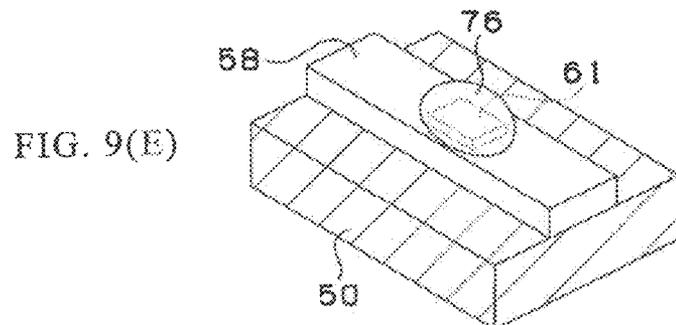
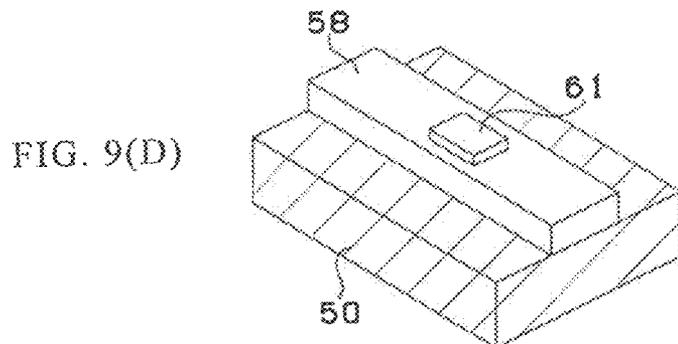
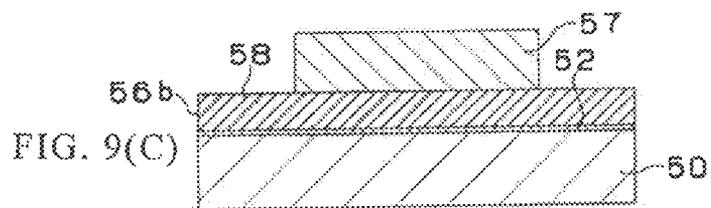
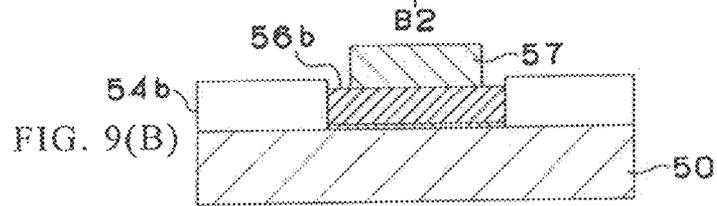
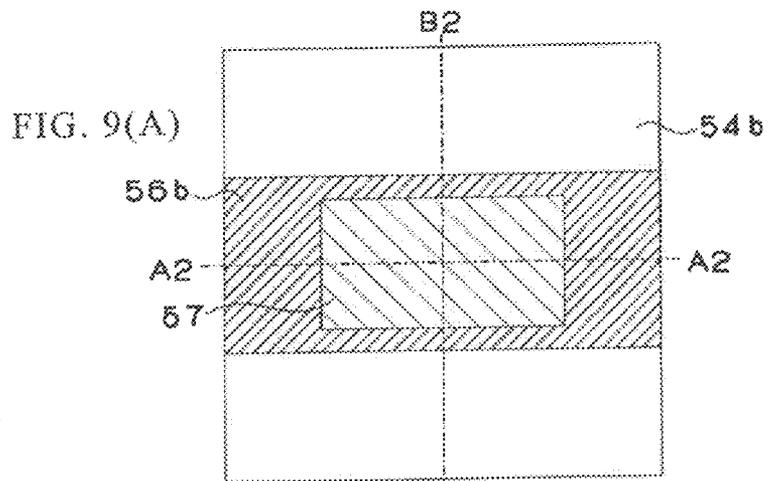


FIG. 10(A)

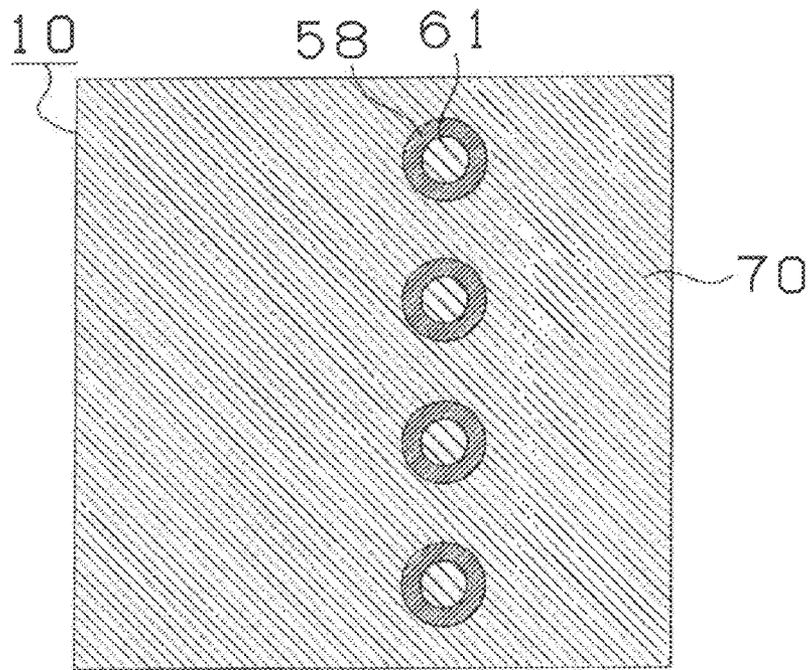


FIG. 10(B)

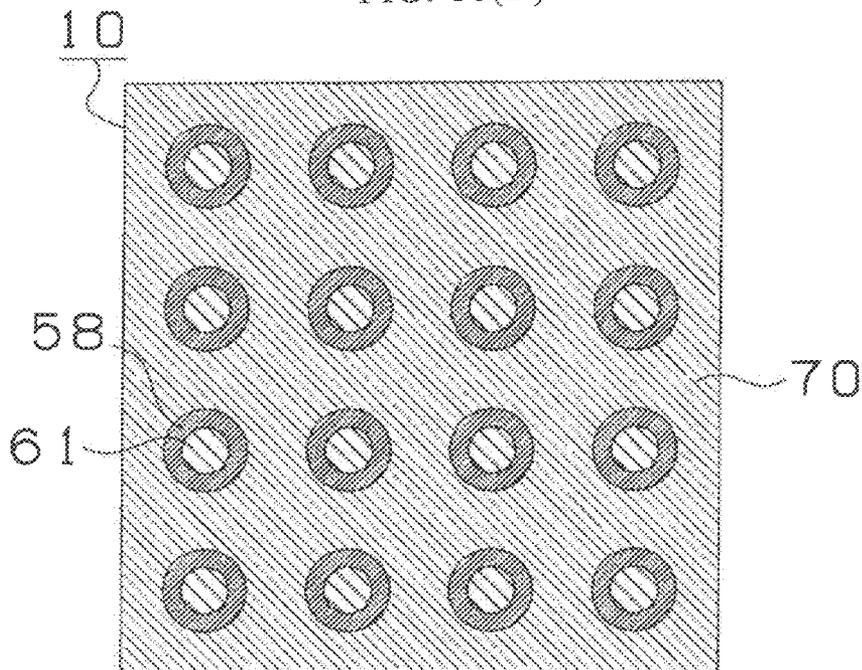


FIG. 11(A)

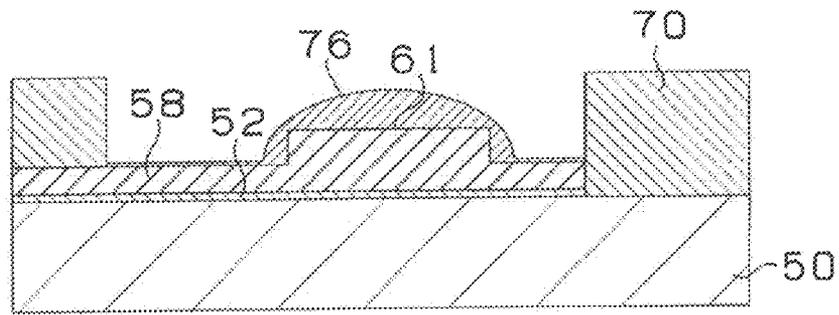


FIG. 11(B)

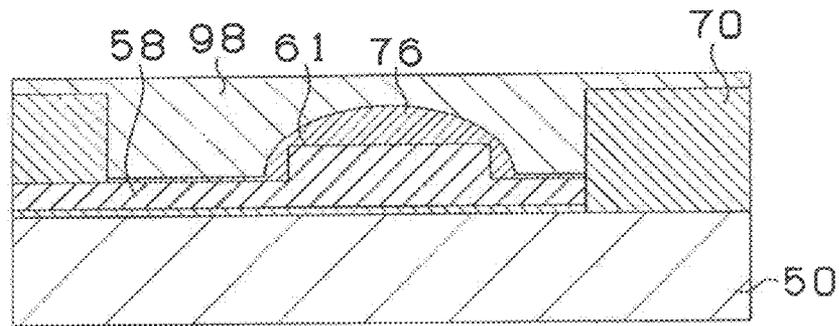


FIG. 11(C)

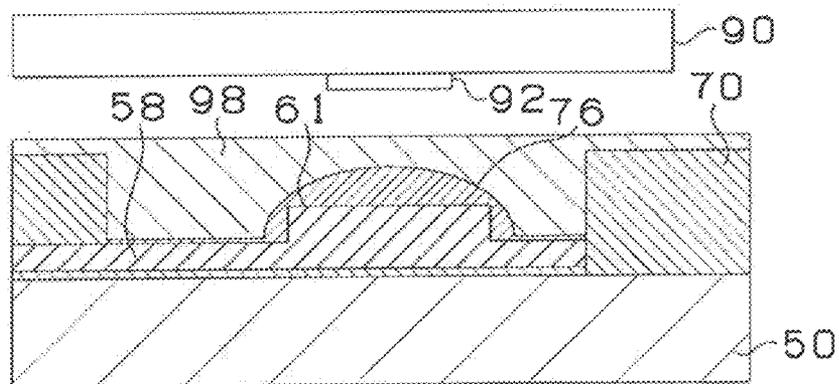
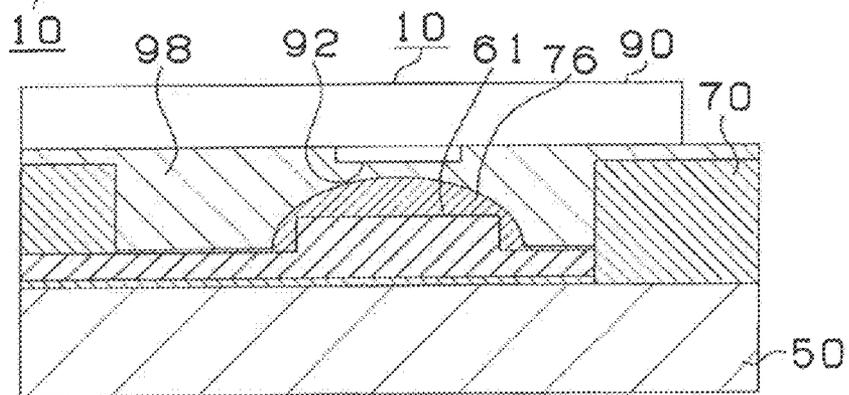
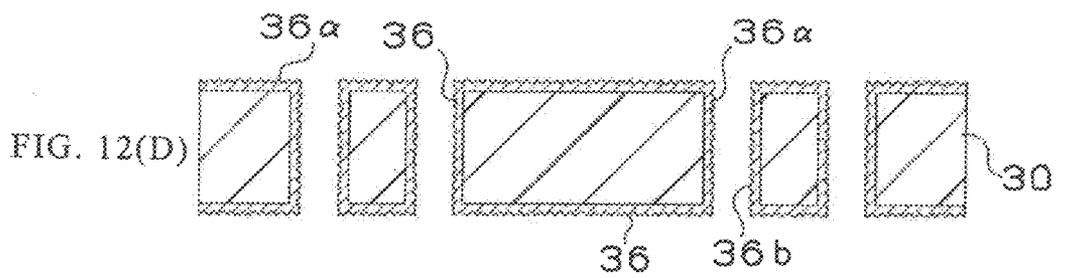
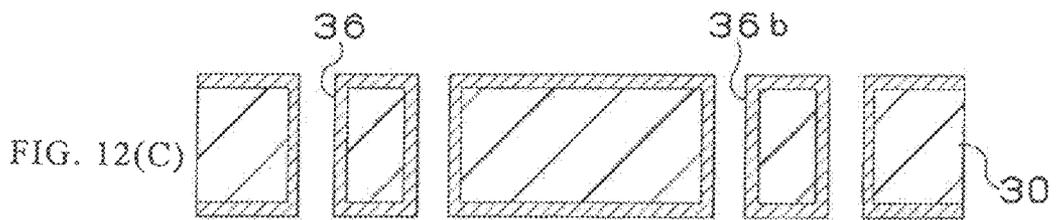
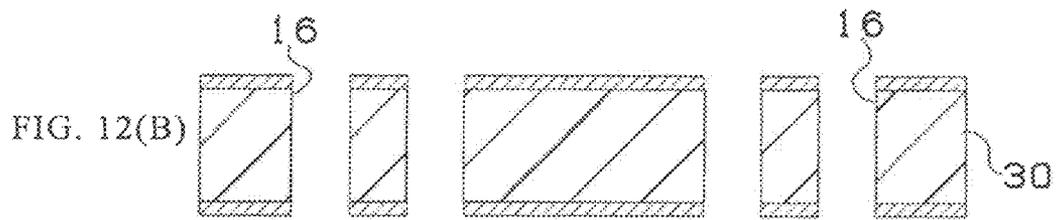
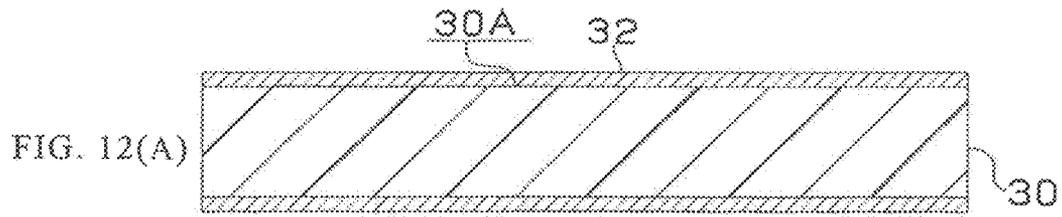


FIG. 11(D)





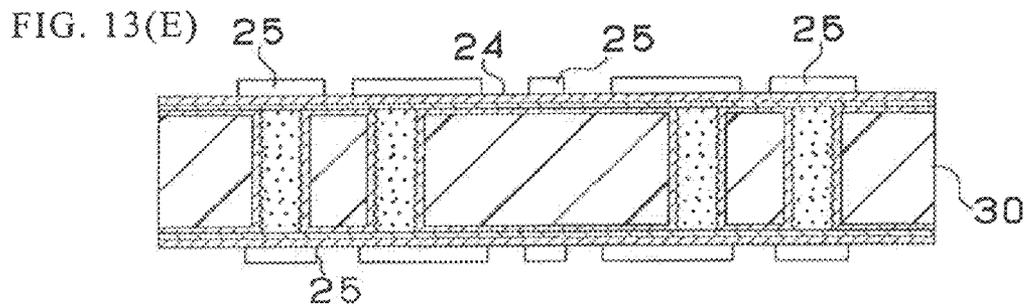
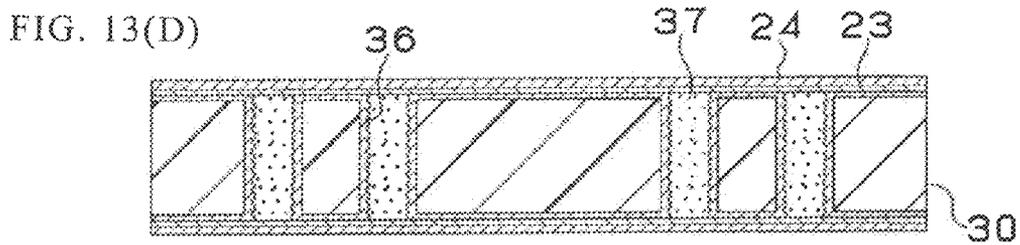
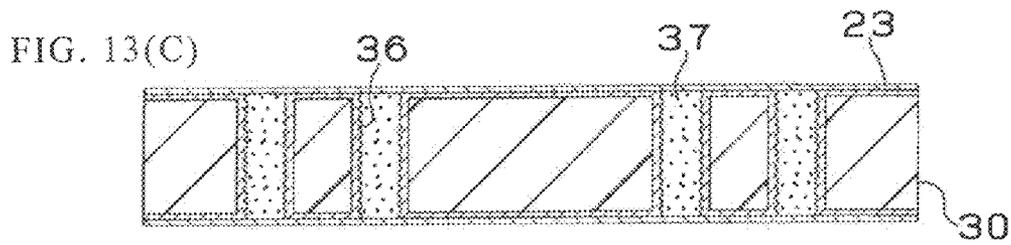
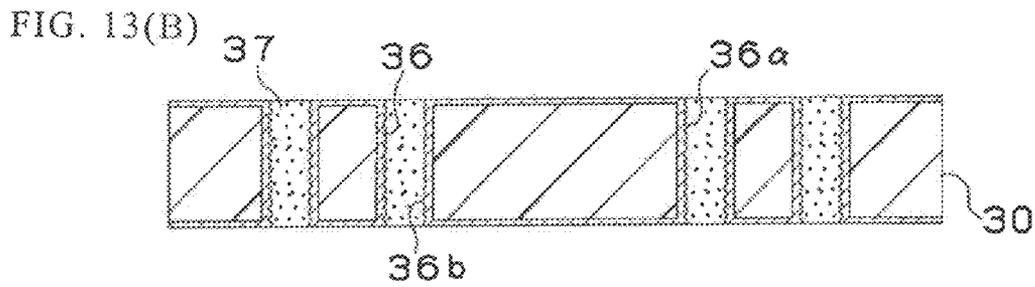
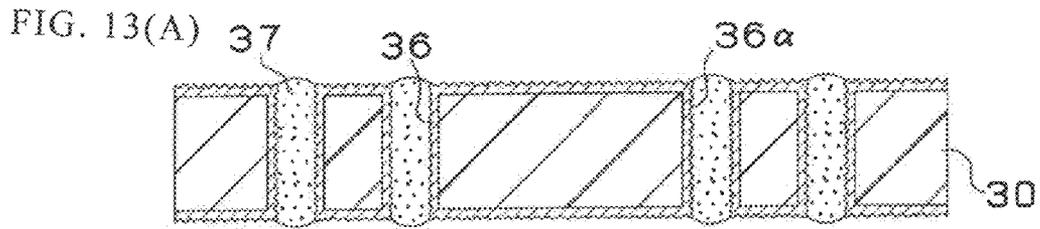


FIG. 14(A)

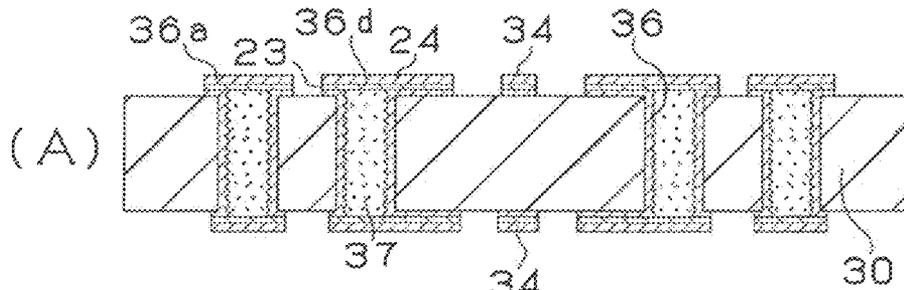


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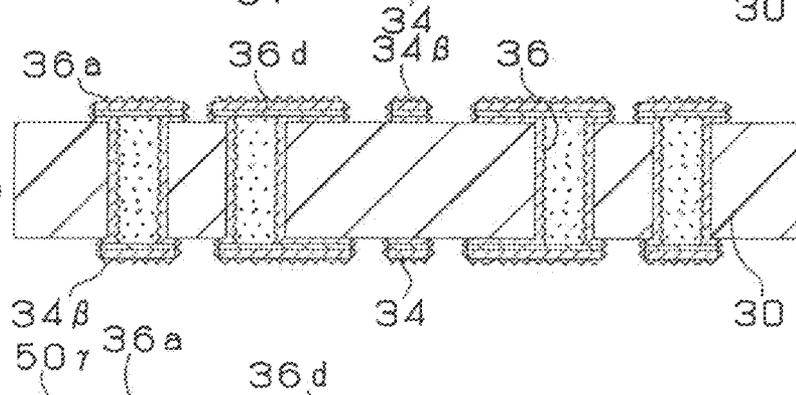


FIG. 14(C)

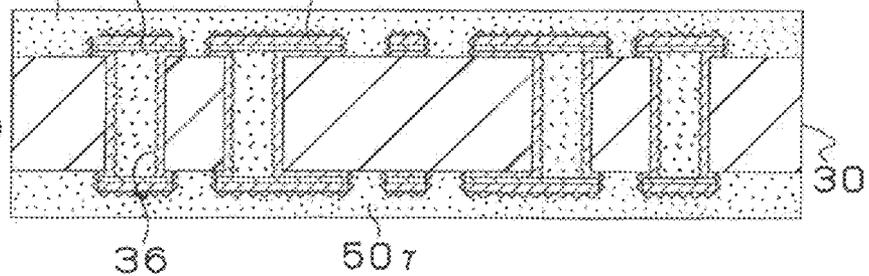


FIG. 14(D)

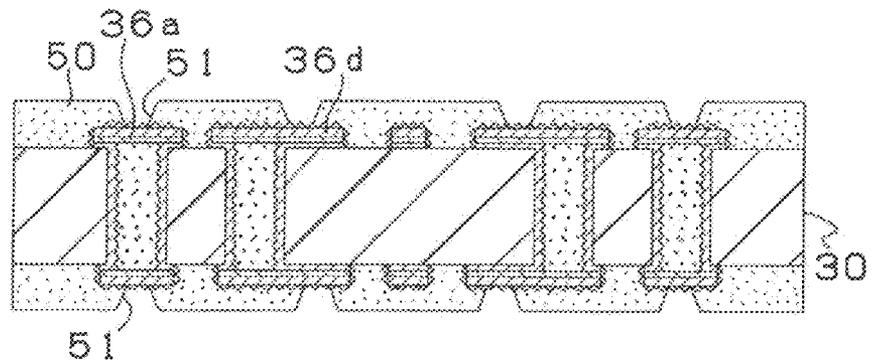


FIG. 15(A)

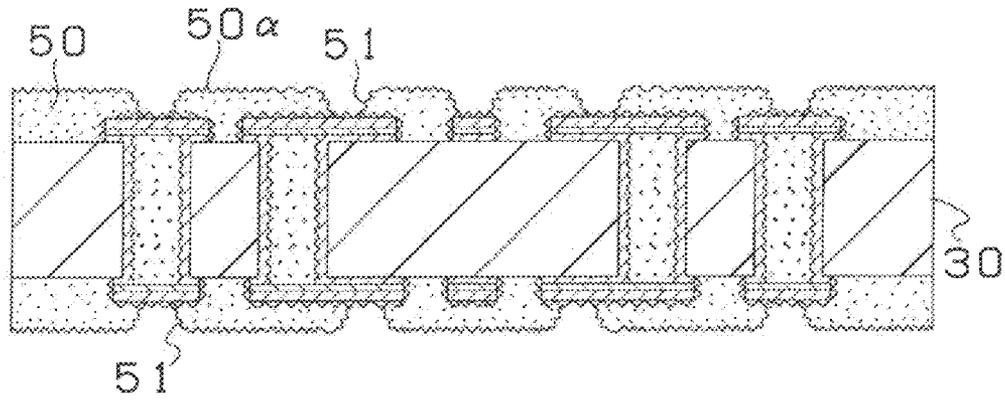


FIG. 15(B)

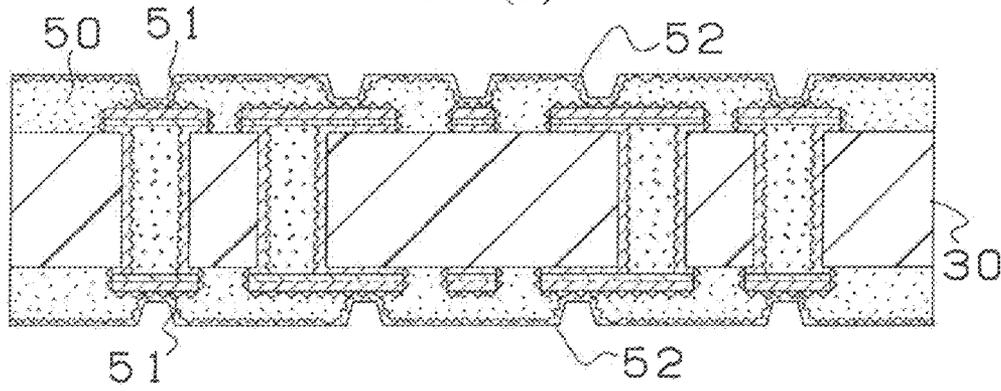


FIG. 15(C)

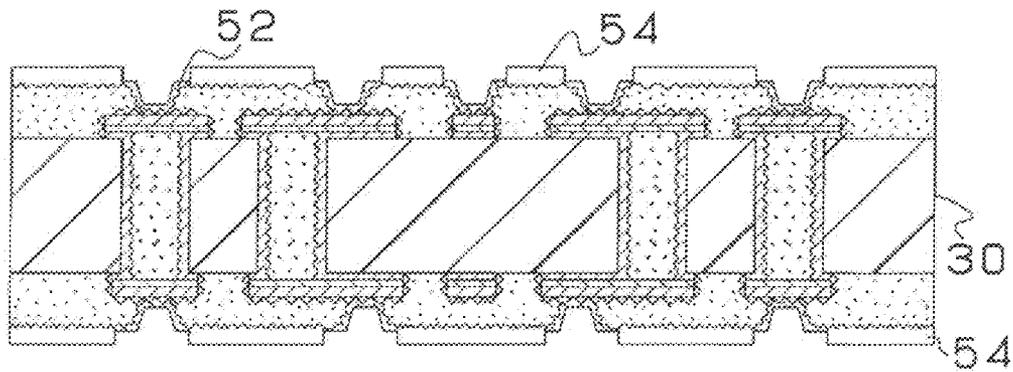


FIG. 16(A)

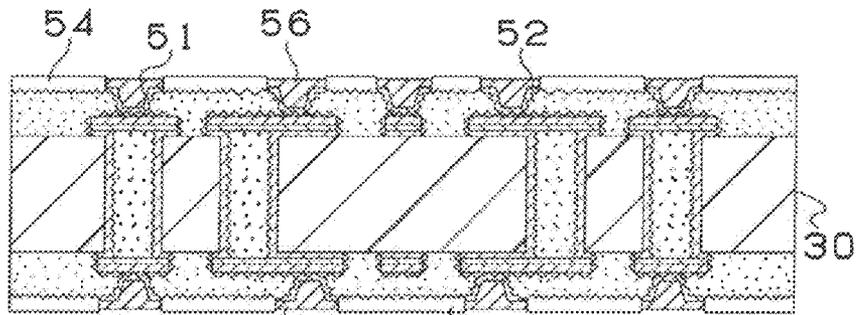


FIG. 16(B)

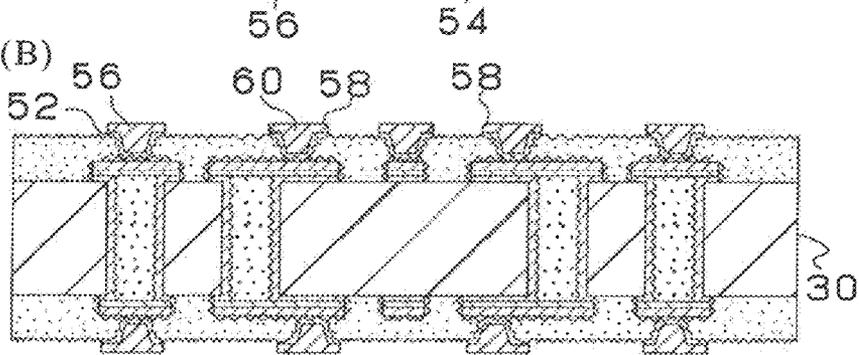


FIG. 16(C)

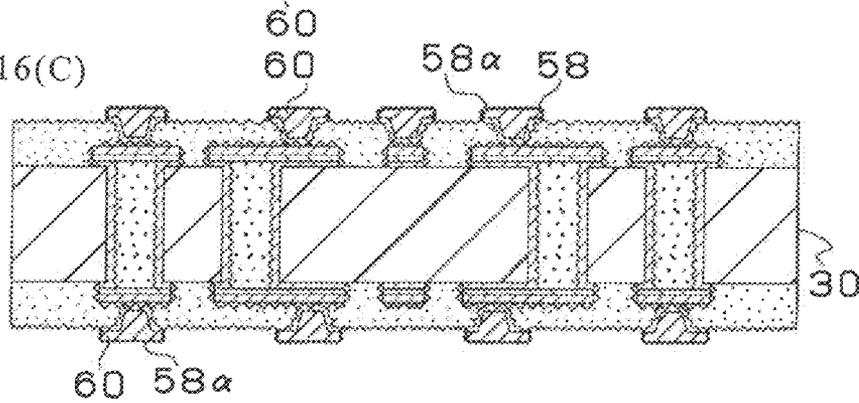


FIG. 16(D)

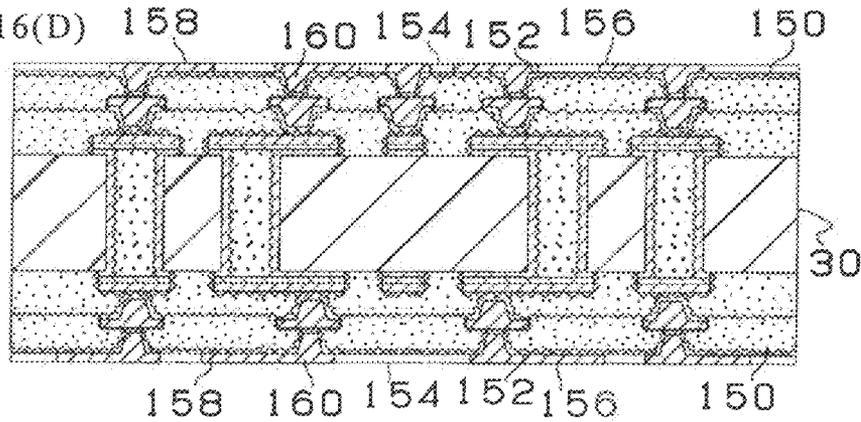


FIG. 17(A)

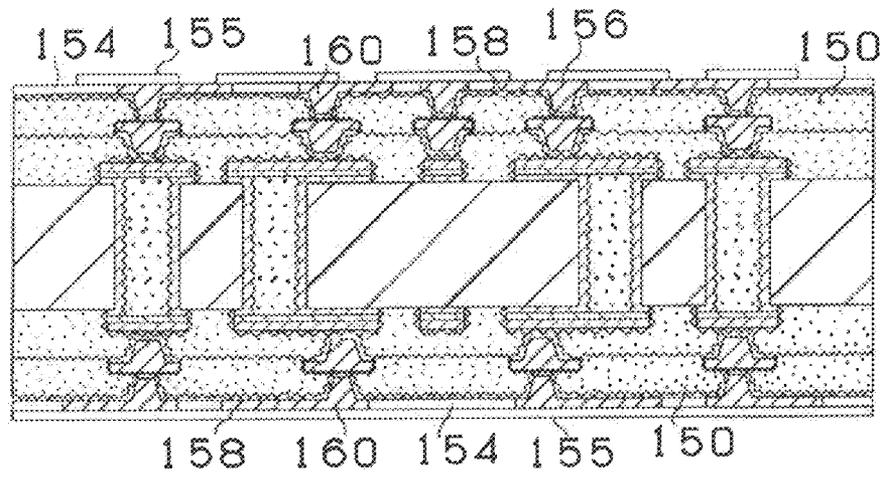


FIG. 17(B)

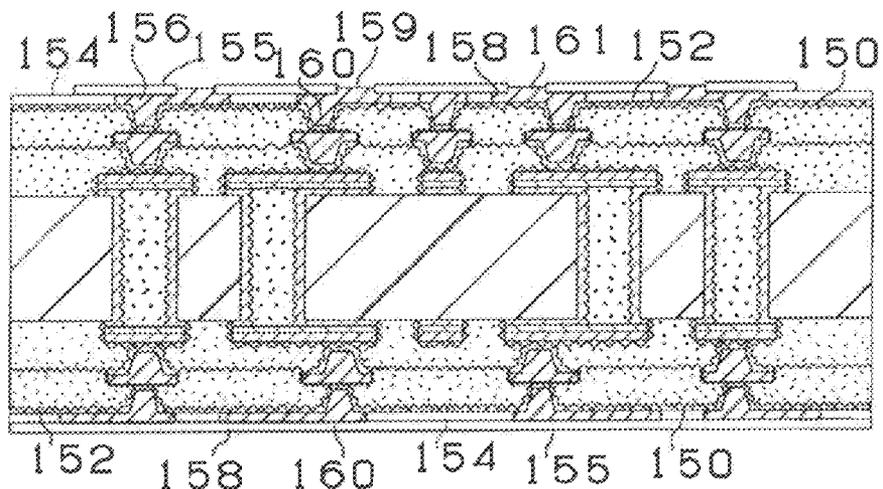


FIG. 17(C)

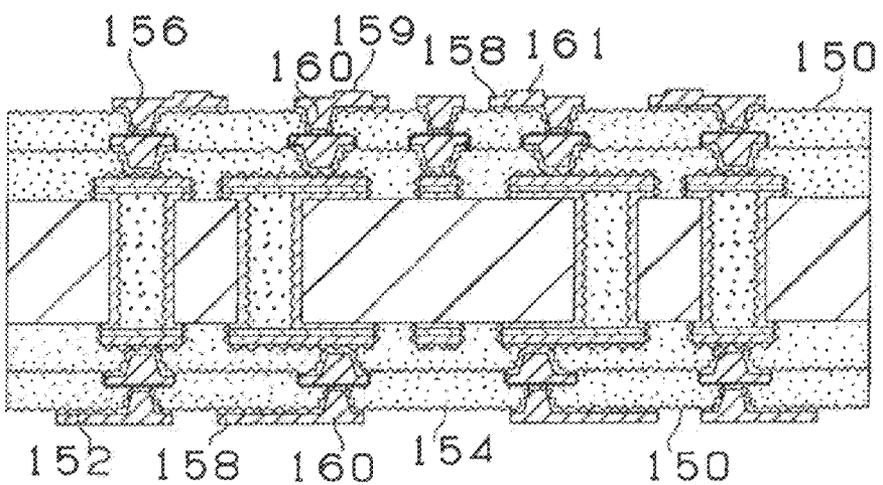


FIG. 18(A)

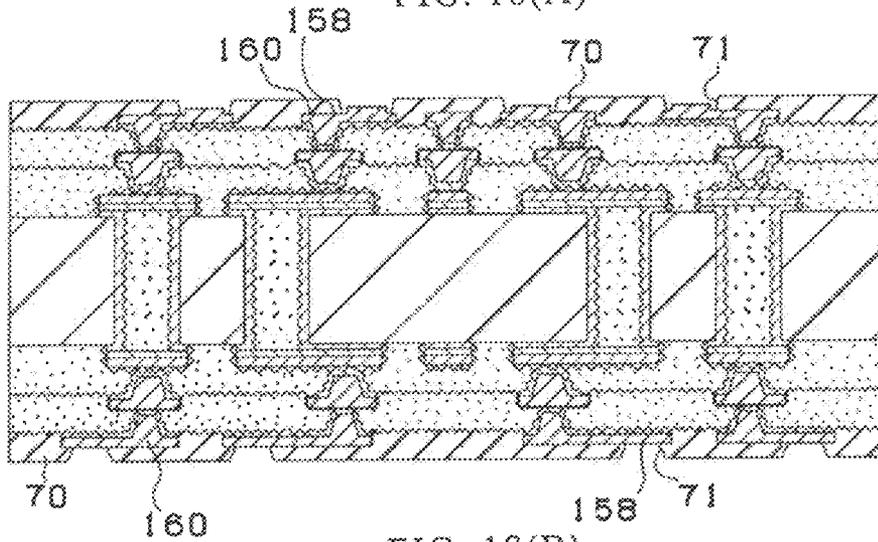


FIG. 18(B)

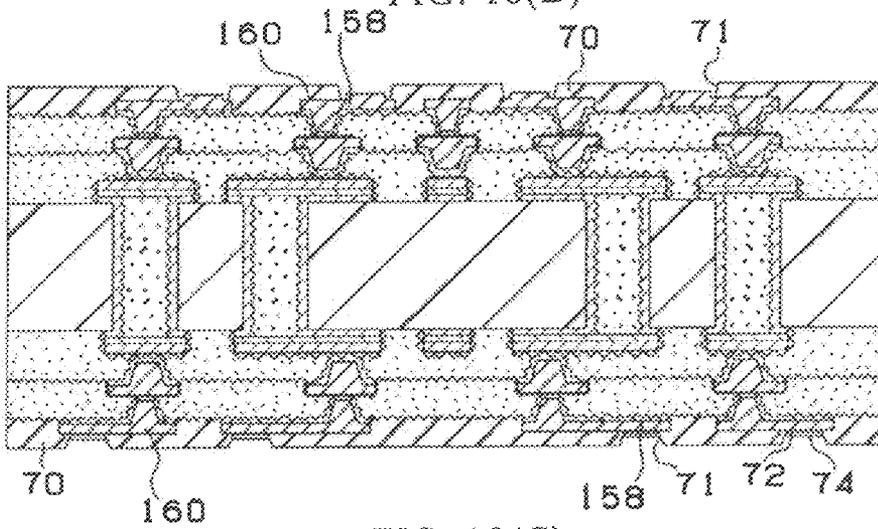
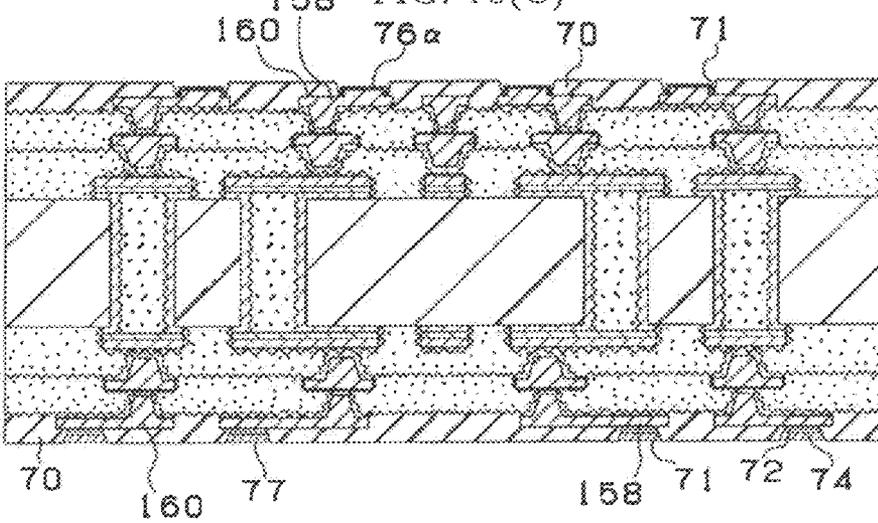


FIG. 18(C)



METHOD FOR MANUFACTURING PRINTED WIRING BOARD AND PRINTED WIRING BOARD

CROSS-REFERENCE TO RELATED APPLICATIONS

The present application claims the benefits of priority to U.S. Application No. 61/156,122, filed Feb. 27, 2009. The contents of that application are incorporated herein by reference in their entirety.

BACKGROUND OF THE INVENTION

1. Field of the Invention

The present invention is related to a printed wiring board on which to mount an electronic component such as an IC chip; especially to a printed wiring board with a pad for flip-chip connection.

2. Discussion of the Background

In Japanese Laid-Open Patent Publication 2006-005158, the content of which are incorporated herein by reference in their entirety, the following is described as a method for manufacturing a printed wiring board having a pad for flip-chip connection as part of a conductive circuit: Namely, a predetermined spot of a conductive circuit to form a pad for flip-chip connection is covered with an etching mask, the thickness of the area left exposed by the etching mask is reduced by half etching, and the pad whose thickness is greater than the half-etched area will be exposed. Also, in Japanese Laid-Open Patent Publication 2006-005158, since the pad is formed thicker relative to the conductive circuit, agglomeration of solder on the pad is not required, and the solder on the pad becomes elevated by the difference between the thickness of the pad and the thickness of the conductive circuit.

SUMMARY OF THE INVENTION

A method for manufacturing a printed wiring board according to one aspect of the present invention is as follows: preparing an insulative board; forming a metal film on a surface of the insulative board; forming a plating resist on the metal film; forming a plated-metal film on the metal film exposed from the plating resist; covering a portion of the plated-metal film with an etching resist; etching to reduce the thickness of the plated-metal film exposed from the etching resist; removing the etching resist; removing the plating resist; by removing the metal film exposed through the removal of the plating resist, forming a wiring made up of a pad and a conductive circuit thinner than the pad; forming a solder-resist layer on the surface of the insulative board and the wiring; forming in the solder-resist layer an opening that exposes the pad and a portion of the conductive circuit contiguous to the pad; forming a solder film on the pad and portion of the conductive circuit exposed through the opening; and forming a solder bump on the pad by agglomerating solder on the pad through a reflow.

A method for manufacturing a printed wiring board according to another aspect of the present invention is as follows: preparing an insulative board; forming a metal film on a surface of the insulative board; covering a portion of the metal film with a first plating resist; forming a first plated-metal film on the metal film exposed from the first plating resist; covering part of the first plated-metal film with a second plating resist; forming a second plated-metal film on the first plated-metal film exposed from the second plating resist;

removing the first and second plating resists; by removing the metal film left exposed by the first and second plated-metal films, forming a wiring made up of a pad and a conductive circuit thinner than the pad; forming a solder-resist layer on the surface of the insulative board and the wiring; forming in the solder-resist layer an opening that exposes the pad and a portion of the conductive circuit contiguous to the pad; forming solder film on the pad and portion of the conductive circuit exposed through the opening; and forming a solder bump on the pad by agglomerating solder on the pad through a reflow.

A printed wiring board according to yet another aspect of the present invention has the following: an insulative board; a wiring formed on a surface of the insulative board, and made up of a pad for mounting an electronic component and of a conductive circuit contiguous to the pad; and a solder bump formed on the pad and a portion of the conductive circuit contiguous to the pad. In such a printed wiring board, the thickness of the pad is greater than the thickness of the conductive circuit, and the thickness of the solder bump on the pad is greater than the thickness of the solder bump on the conductive circuit.

BRIEF DESCRIPTION OF THE DRAWINGS

A more complete appreciation of the invention and many of the attendant advantages thereof will be readily obtained as the same becomes better understood by reference to the following detailed description when considered in connection with the accompanying drawings, wherein:

FIG. 1 are cross-sectional views and a top view of a multilayer printed wiring board according to an embodiment of the present invention;

FIG. 2 are views showing the steps of a method for manufacturing a printed wiring board according to the first embodiment;

FIG. 3 are views showing the steps of a method for manufacturing a printed wiring board according to the first embodiment;

FIG. 4 are views showing the steps of a method for manufacturing a printed wiring board according to the first embodiment;

FIG. 5 are views showing the steps of a method for manufacturing a printed wiring board according to the second embodiment;

FIG. 6 are views showing the steps of a method for manufacturing a printed wiring board according to the second embodiment;

FIG. 7 are views showing the steps of a method for manufacturing a printed wiring board according to the second embodiment;

FIG. 8 is a top view and cross-sectional views showing a modified example of the multilayer printed wiring board according to the first embodiment;

FIG. 9 is a top view and cross-sectional views showing a modified example of the multilayer printed wiring board according to the second embodiment;

FIG. 10 is plan views showing modified examples of a printed wiring board according to the present invention;

FIG. 11 are views showing the steps of a method for manufacturing a printed wiring board according to the third embodiment;

FIG. 12 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 13 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 14 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 15 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 16 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 17 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 18 are views showing the steps of a method for manufacturing a multilayer printed wiring board according to the first example of the present invention;

FIG. 19 is a cross-sectional view of a multilayer printed wiring board according to the first example; and

FIG. 20 is a cross-sectional view showing a state in which an IC chip is mounted on a multilayer printed wiring board according to the first embodiment.

DETAILED DESCRIPTION OF THE EMBODIMENTS

The embodiments will now be described with reference to the accompanying drawings, wherein like reference numerals designate corresponding or identical elements throughout the various drawings.

First Embodiment

The structure of a printed wiring board according to the present invention is described with reference to FIGS. 1A-1C. FIG. 1A is a cross-sectional view showing multilayer printed wiring board 10. In multilayer printed wiring board 10, conductive circuits 34 are formed on the surfaces of core substrate 30. The front and back surfaces of core substrate 30 are connected by means of through-holes 36. Through-holes 36 are made up of plated cover layers (36a, 36d) which form through-hole lands and of side-wall conductive layers (36b). In the interiors surrounded by side-wall conductive layers (36b), resin filler 37 is filled. Resin insulation layers 50 having filled vias 60 and conductive circuits 58 and resin insulation layers 150 having filled vias 160 and conductive circuits 158 are formed on plated cover layers (through-hole lands) (36a, 36d). Pads 161 are formed at predetermined spots of upper-side conductive circuits 158. Solder bumps 76 are arranged on pads 161. Solder resist layers 70 are formed on resin insulation layers 150. Part of conductive circuits 158 and pads 161 are exposed through opening portions 71 of upper-side solder resist layer 70; and bumps 78 are formed in lower-side opening portions 71.

FIG. 1B is a magnified top view showing part of multilayer printed wiring board 10. FIG. 1C is a cross-sectional view seen from the (A-A') line in FIG. 1B. The thickness of pad 161 is set to be greater than the thickness of conductive circuit 158, preferably approximately 2-10 μm thicker. On pad 161, solder bump 76 is formed with a mountain-shaped profile or a half-elliptic profile. Solder film (76 β) is formed on conductive circuit 158 left exposed by solder-resist layer 70. The thickness of solder bump 76 on pad 161 is preferred to be 1.1-1.5 times thicker than the thickness of solder film (76 β) on conductive circuit 158. The thickness of the solder bump on the pad according to the present invention indicates the largest thickness of solder bump 76 measured from the top surface of pad 161; and the thickness of the solder film on the conductive circuit indicates the largest thickness of solder film (760)

measured from the top surface of conductive circuit 158. As FIG. 1D shows another example of FIG. 1C, metal layer 172 selected from among Ni, Au, Sn, Pd, Ag and Pt may be formed on conductive circuit 158. By forming a metal layer, oxidation of the surface of the conductive circuit may be prevented.

Next, a method for manufacturing printed wiring board 10 according to the first embodiment of the present invention is described with reference to FIGS. 2-4.

(1) On insulation layer 50 made of resin (FIG. 2A), metal film 52 made of copper or the like is formed (FIG. 2B). Such metal film may be formed by forming electroless plated-metal film, forming electroless plated-metal film and electrolytic plated-metal film, pressing metal foil on a prepreg and so forth.

(2) First plating resist (54a) for forming a pad and conductive circuit is formed on metal film 52 (FIG. 2C). Then, the substrate is immersed in an electrolytic plating solution, and an electrical current is passed through metal film 52. Accordingly, first electrolytic copper-plated film (56a) is formed in the area where plating resist is not formed (FIG. 2D).

(3) Second plating resist 55 for forming a pad is formed on first electrolytic copper-plated film (56a), which will become conductive circuit (FIG. 3A). The substrate is immersed in an electrolytic plating solution, and second electrolytic copper-plated film 59 with a thickness of 2-10 μm is formed on the area of first electrolytic copper-plated film (56a) where second plating resist 55 is not formed (FIG. 3B).

(4) First plating resist (54a) and second plating resist 55 are removed and the following are formed: conductive circuit 58 made from first electrolytic copper-plated film (56a), and pad 61 made up of first electrolytic copper-plated film (56a) and second electrolytic copper-plated film 59 formed on first electrolytic copper-plated film (56a) (FIG. 3C). Then, metal film 52 under first plating resist (54a) is removed by etching (FIG. 3D). In doing so, conductive circuit 58 with thickness (h1) of 15 μm and pad 61 with thickness (h2) of 18-25 μm are formed.

(5) On insulation layer 50, opening portion 71 exposing pad 61 is arranged and solder resist layer 70 with thickness (h3) of 25-35 μm is formed (FIG. 3E). After that, metal layer 172 shown in FIG. 1D to prevent oxidation may be formed. In yet another example, such a metal layer may be formed after electrolytic copper-plated film 59 shown in FIG. 3B is formed. In such a case, a metal film is formed only on the top surface of the pad (FIG. 3F).

(6) On pad 61 and conductive circuit 58 exposed through opening portion 71, solder paste (76 α) is printed with a thickness (W6) of $3\pm 1.5 \mu\text{m}$ (FIG. 4A). FIG. 4B is a plan view of FIG. 4A. Width (W1) of pad 61 and conductive circuit 58 is 25 μm ; length (L1) of pad 61 is 100 μm ; and the application length of the solder paste (L2=length of the pad+the length of the conductive circuit left exposed by the solder resist) is 300 μm . Then, a reflow is conducted at 250° C. for 0.5 minute. The solder which is fused during the reflow is formed into a sphere by surface tension. During that time, to make an even more stable sphere, the solder on conductive circuit 58 also agglomerates. Accordingly, solder bump 76 with a half-elliptic profile is formed on pad 61, which is a protruding portion, and thin solder film (76 β) is formed on conductive circuit 58 (FIG. 4C). In doing so, printed wiring board 10 is complete. Here, height (H4) of the solder bump is 15 μm , thickness (H5) of solder film (76 β) on conductive circuit 58 is 1 μm , and length (L3) of the solder bump becomes (100+ α) μm . As for the solder to make solder paste, metal mainly containing Sn/Pb, Sn/Ag, Sn/Sb, Sn/Ag/Cu or the like may be used.

In the following, mounting an IC chip on printed wiring board **10** is described.

Gold-stud bump **91** of IC chip **90** to be mounted on the printed wiring board is aligned to face pad **61** of printed wiring board **10** (FIG. 4D). Then, IC chip **90** is pressed against printed wiring board **10**, gold-stud bump **91** and pad **61** are connected, IC chip **90** is mounted on printed wiring board **10**, and underfill (UF) is filled between IC chip **90** and printed wiring board **10** (FIG. 4E). The thickness of pad **61** is preferred to be set lower than solder-resist layer **70**. It is possible to form pad **61** to be thicker than solder-resist layer **70**; however, since the mounting position of an electronic component rises, the pad is preferred to be set lower than a protective layer from the viewpoint of making a lightweight and thinner type.

In a printed wiring board according to the manufacturing method of the first embodiment, pad **61** is made up of first electrolytic copper-plated film (**56a**) and second electrolytic copper-plated film **59** with a thickness of 2-10 μm , and is 2-10 μm thicker than conductive circuit **58** made from first electrolytic copper-plated film (**56a**). Moreover, solder bump **76** with a thickness of 15 μm is formed on pad **61**. Thus, when IC chip **90** is pressed against printed wiring board **10** to connect gold-stud bump **91** and solder bump **76** of pad **61**, IC chip **90** does not come in contact with solder-resist layer **70**. Accordingly, sufficient pressure may be exerted to enhance connection reliability between gold-stud bump **91** and solder bump **76** of pad **61**.

Furthermore, since the width of pad (**61**) is the same as that of conductive circuit (**58**), it is not necessary to distribute conductive circuit (**58**) away from pad (**61**) to keep insulation distance from pad (**61**). Accordingly, fine-pitch conductive circuit (**58**) may be arranged.

In addition, since the thickness is increased by forming the second plated-metal film on the first plated-metal film, compared with a manufacturing method in which the thickness of the conductive circuit is reduced through etching using an etching resist, side etching will not occur on the pad and conductive circuit. Thus, connection reliability will not decrease in the pad and conductive circuit.

In a printed wiring board according to the manufacturing method of the first embodiment, solder bump **76** is formed on pad **61**, which is then connected to gold-stud bump **91**. Since the pad is thick, heavy pressure may be exerted when gold-stud bump **91** is pressed against solder bump **76** of pad **61**, leading to high connection reliability.

Moreover, in a printed wiring board according to the manufacturing method of the first embodiment, when gold-stud bump **91** is pressed against solder bump **76** of pad **61**, even if solder resist layer **70** comes in contact with IC chip **90**, connection reliability may be enhanced, since pad **61** is thick and the pressure exerted on gold-stud bump **91** is heavy.

Since thin solder film (**76 β**) is coated on conductive circuit **58** left exposed by the solder-resist layer, solder film (**76 β**) will not cross over solder-resist **70** to cause a solder bridge between portions of solder.

Second Embodiment

A method for forming printed wiring board **10** according to the second embodiment of the present invention is described with reference to FIGS. 5-7.

(1) On insulation layer **50** made of resin (FIG. 5A), metal film **52** made of copper or the like is formed (FIG. 5B). Such metal film may be formed by electroless copper plating. Here, instead of forming plated-metal film, metal foil may be laminated.

(2) Plating resist (**54b**) for forming a pad and conductive circuit is formed on metal film **52** (FIG. 5C). Then, the substrate is immersed in an electrolytic plating solution, and an electrical current is passed through metal film **52**. Accordingly, electrolytic copper-plated film (**56b**) with a thickness of 18-25 μm is formed in the area where plating resist is not formed (FIG. 5D).

(3) Etching resist **57** is formed on the area of electrolytic copper-plated film (**56b**) that will become a pad (FIG. 6A). The substrate is immersed in an etchant, and portions of the surface of electrolytic copper-plated film **56** where etching resist **57** is not formed are etched away by a thickness of 2-10 μm (FIG. 6B). The resultant portions will become conductive circuit.

(4) Plating resist (**54b**) and etching resist **57** are removed and the following are formed: conductive circuit **58** made from the portions of electrolytic copper-plated film (**56b**) which were etched by a thickness of 2-10 μm , and pad **61** made from the portion of electrolytic copper-plated film (**56b**) which was not etched (FIG. 6C). Then, metal film **52** under plating resist (**54b**) is removed by etching (FIG. 6D). By doing so, conductive circuit **58** with thickness (**h1**) of 15 μm and pad **61** with thickness (**h2**) in the range of 18-25 μm are formed.

(5) Opening portion **71** exposing pad **61** is arranged on insulation layer **50**, and solder resist layer **70** with thickness (**h3**) in the range of 25-35 μm is formed (FIG. 6E).

(6) On pad **61** and conductive circuit **58** exposed through opening portion **71**, solder paste (**76 α**) is printed with a thickness (**W6**) of 3 ± 1.5 μm (FIG. 7A). FIG. 7B is a plan view of FIG. 7A. Width (**W1**) of pad **61** and conductive circuit **58** is 25 μm ; length (**L1**) of pad **61** is 100 μm ; and the application length of the solder paste (**L2**=length of the pad+the length of the conductive circuit left exposed by the solder resist) is 300 μm . Then, a reflow is conducted at 250° C. for 0.5 minute. The solder which is fused during the reflow is formed into a sphere by surface tension. During that time, to make an even more stable sphere, the solder on conductive circuit **58** also agglomerates. Accordingly, solder bump **76** with a half-elliptic profile is formed on pad **61**, which is a protruding portion, and thin solder film (**76 β**) is formed on conductive circuit **58** (FIG. 7C). In doing so, printed wiring board **10** is complete. Here, height (**H4**) of the solder bump is 15 μm , thickness (**H5**) of solder film (**76 β**) on conductive circuit **58** is 1 μm , and length (**L3**) of the solder bump becomes $100+\alpha$ μm . It is possible to form a metal layer using at least a metal selected from among Ni, P, Au, Sn, Pd, Ag and Pt, and then forming solder film before printing solder paste (**76 α**) on pad **61** and conductive circuit **58** exposed through opening portion **71**.

Next, mounting an IC chip on printed wiring board **10** is described.

Gold-stud bump **91** of IC chip **90** to be mounted on the printed wiring board is aligned to face pad **61** of printed wiring board **10** (FIG. 7D). Then, IC chip **90** is pressed against printed wiring board **10**, gold-stud bump **91** and pad **61** are connected, IC chip **90** is mounted on printed wiring board **10**, and underfill (UF) is filled between IC chip **90** and printed wiring board **10** (FIG. 7E).

In printed wiring board **10** according to the manufacturing method of the second embodiment, pad **61** is thicker than conductive circuit **58**, whose thickness is etched away by 2-10 μm . Moreover, solder bump **76** with a thickness of 15 μm is formed on pad **61**. Thus, when IC chip **90** is pressed against printed wiring board **10** to connect gold-stud bump **91** and solder bump **76** of pad **61**, IC chip **90** does not come in contact with solder-resist layer **70**, and connection reliability is

enhanced between gold-stud bump **91** and solder bump **76** of pad **61** by exerting sufficient pressure.

Furthermore, the width of pad **61** is the same as the width of conductive circuit **58**. Thus, it is not necessary to distribute conductive circuit **58** away from pad **61** to keep insulation distance from pad **61**. Thus, fine-pitch conductive circuit **58** may be arranged.

Also, during the etching, because plating resist (**54a**) remains on the side surface of pad **61** and the side surface of conductive circuit **58**, side etching will not occur on pad **61** and conductive circuit **58**. Thus, reliability will not decrease in the pad and wiring, compared with a manufacturing method in which side etching will occur during etching using an etching resist to reduce the thickness of the wiring.

In printed wiring boards according to the first and second embodiments, multiple rectangular pads **61** are exposed through opening **71** arranged in solder-resist layer **70**. However, as shown in FIG. **10A**, pads **61** with a substantially circular shape may be formed. Also, as shown in FIG. **10B**, only pads may be formed in a grid configuration and exposed through the solder resist, which is higher than such pads.

Furthermore, as a modified example of the first embodiment, the following method may also be employed. FIG. **8A** is a top view showing second plating resist **55** formed on printed wiring board **10**. FIGS. **8B** and **8C** are cross-sectional views taken respectively from the (B1-B1) line and (A1-A1) line in FIG. **8A**. Second plating resist **55** is formed to be narrower than the width of the first electrolytic copper-plated film. In such a case, pad **61** formed later will be set to be narrower than conductive circuit **58** both lengthwise and crosswise as shown in FIG. **8D**. Then, solder bump **76** is formed on pad **61** by printing solder paste and conducting a reflow (FIG. **8E**). In such a modified example, solder bump **76** is formed on pad **61**, which has a smaller area than the conductive circuit. Thus, solder bump **76** here has an advantage in that its height may be set higher compared with the first embodiment.

Also, the following may be employed as a modified example of the second embodiment.

FIG. **9A** is a top view showing etching resist **57** formed on the first electrolytic copper-plated film. FIGS. **9B** and **9C** are cross-sectional views taken respectively from the (B2-B2) line and (A2-A2) line in FIG. **9A**. Etching resist **57** is formed to be narrower than the width of the first electrolytic copper-plated film. In such a case, pad **61** formed later will be set to be narrower than conductive circuit **58** both lengthwise and crosswise as shown in FIG. **9D**. Then, solder bump **76** is formed on pad **61** by printing solder paste and conducting a reflow (FIG. **9E**). In such a modified example, solder bump **76** is formed on pad **61**, which has a smaller area than the conductive circuit. Thus, solder bump **76** here has an advantage in that its height may be set higher compared with the second embodiment.

Third Embodiment

A method for manufacturing printed wiring board **10** according to the third embodiment of the present invention is described with reference to FIG. **11**.

Using steps (1)-(4) of the first embodiment or steps (1)-(4) of the second embodiment, wiring **58** and pad **61**, which is set to be 2-10 μm thicker than the wiring, and solder bump **76** with a height of 15 μm are formed on insulation layer **50** (FIG. **11A**). Then, anisotropic conductive film (ACF) **98**, containing conductive particles made of metal or the like in resin film, is arranged on insulation layer **50**, and printed wiring board **10** is completed (FIG. **11B**).

Bump **92** of IC chip **90** to be mounted on a printed wiring board is aligned to face pad **61** of printed wiring board **10** (FIG. **11C**). Then, IC chip **90** is pressed against printed wiring board **10**, bump **92** and pad **61** are connected by means of ACF **98**, and IC chip **90** is mounted on printed wiring board **10** (FIG. **11D**).

In printed wiring board **10** of the third embodiment, since pad **61** is thicker than wiring **58** and solder bump **76** is further formed, only pad **61** makes connection with bump **92** by means of anisotropic conductive film (ACF) **98** without causing short-circuiting in wiring **58**.

EXAMPLES

First Example

The structure of built-up multilayer printed wiring board **10** according to the first example of the present invention is described with reference to FIGS. **12-20**. FIG. **19** is a cross-sectional view showing multilayer printed wiring board **10**, and FIG. **20** is a view showing a state in which IC chip **90** is mounted on multilayer printed wiring board **10** shown in FIG. **19**, which is further mounted on daughterboard **94**. As shown in FIG. **19**, in multilayer printed wiring board **10**, conductive circuits **34** are formed on the surfaces of core substrate **30**. The front and back surfaces of core substrate **30** are connected by means of through-holes **36**. Through-holes **36** are made up of plated cover layers (**36a**, **36d**) which form through-hole lands and of side-wall conductive layers (**36b**). Resin filler **37** is filled in the interiors surrounded by side-wall conductive layers (**36b**). Resin insulation layers **50** having filled vias **60** and conductive circuits **58** and resin insulation layers **150** having filled vias **160** and conductive circuits **158** are formed on plated cover layers (through-hole lands) (**36a**, **36d**). Pads **161** are formed at predetermined spots of upper-side conductive circuit **158**, and solder bumps **76** are formed on pads **161**. Solder resist layers **70** are formed on resin insulation layers **150**. Pads **161** are exposed through opening portions **71** of upper-side solder resist layer **70**; and bumps **78** are formed in lower-side opening portions **71**.

As shown in FIG. **20**, solder bumps **76** of upper-side pads **161** of multilayer printed wiring board **10** are connected to bumps **92** of IC chip **90** by means of gold-stud bumps **91**. Meanwhile, lower-side solder bumps **78** are connected to lands **96** of daughterboard **94**.

Next, a method for manufacturing multilayer printed wiring board **10** described with reference to FIG. **20** is described by referring to FIGS. **12-19**.

(1) Copper-clad laminate (**30A**) was prepared as a starting material. The copper clad-laminate was made by laminating copper foil **32** with a thickness of 5-250 μm on both surfaces of insulative substrate **30** made of glass-epoxy resin or bismaleimide triazine (BT) resin with a thickness of 0.2-0.8 mm (FIG. **12A**). First, by drilling the copper-clad laminate, penetrating holes **16** were formed (FIG. **12B**). Then, side-wall conductive layers (**36b**) of through-holes **36** were formed by performing electroless plating and electrolytic plating (see later-described plating solution and conditions (steps (13) and (15)) (FIG. **12C**). The opening diameter of penetrating holes **16** was set at $\Phi 0.1-0.25$ mm by drill selection, and the pitch was set at 0.15-0.575 mm.

(2) Substrate **30** with through holes **36** was washed with water and dried, a black-oxide treatment was conducted using a solution containing NaOH (10 g/l), NaClO₂ (40 g/l) and Na₃PO₄ (6 g/l) as a black-oxide bath (oxidation bath), followed by a reduction treatment using a solution containing NaOH (10 g/l) and NaBH₄ (6 g/l) as a reduction bath. Accord-

ingly, roughened surfaces (36 α) were formed on side-wall conductive layers (36 b) of through-holes 36 and on the surfaces of the substrate (FIG. 12D).

(3) Next, filler 37 (non-conductive copper paste padding, brand name: DD paste, made by Tatsuta Electric Wire & Cable, Co., Ltd.) containing copper particles with an average particle diameter of 10 μm was filled in through-holes 36 by screen printing, dried and cured (FIG. 13A). A mask with openings corresponding to through-hole portions was placed on the substrate, and the paste was applied by printing to fill the through-holes. After that, the paste was dried and cured.

In the following, filler 37 bulging from through-holes 36 was removed by belt-sander polishing using #600 belt sanding paper (made by Sankyo-Rikagaku Co., Ltd.). Then, buff polishing to remove scratches from such belt sanding was conducted to level the surfaces of substrate 30 (see FIG. 13B). In doing so, substrate 30 was obtained where side-wall conductive layers (36 b) of through-holes 36 and resin filler 37 were firmly adhered by means of roughened layer (36 a).

(4) On the surfaces of substrate 30 leveled in step (3), palladium catalyst (made by Atotech) was applied and electroless copper plating was performed. Accordingly, electroless copper-plated films 23 with a thickness of 0.6 μm were formed (see FIG. 13C).

(5) Next, electrolytic copper plating was performed under the following conditions to form electrolytic copper-plated films 24 with a thickness of 15 μm . The portions that will become conductive circuits 34 were thickened, and the portions that will become plated cover layers (through-hole lands) to cover filler 37 filled in through-holes 36 were formed (FIG. 13D).

[Electrolytic Plating Solution]

sulfuric acid	180 g/l
copper sulfate	80 g/l
additive (brand name: Cupracid GL, made by Atotech Japan)	1 ml/l

[Electrolytic Plating Conditions]

current density	1 A/dm ²
time	30 minutes
temperature	room temperature

(6) On both surfaces of substrate 30 where portions that will become conductive circuits and plated-cover layers were formed, commercially available photosensitive dry film was laminated, and a patterned mask was placed on the film, which was then exposed to light at 100 mJ/cm² and developed with a 0.8% sodium carbonate solution. Accordingly, etching resists 25 with a thickness of 15 μm were formed (see FIG. 13E).

(7) Next, portions of plated-metal films (23, 24) and copper foil 32 where etching resist 25 was not formed were dissolved and removed by an etchant mainly containing copper (II) chloride. Then, etching resists 25 were removed by a 5% KOH solution. Accordingly, independent circuits 34 and plated-cover layers (36 a , 36 d) covering filler 37 were formed (see FIG. 14A). This process is a so-called tenting method.

(8) Next, roughened layers (34 β) were formed on the surfaces of conductive circuit 34 and plated-cover layers (36 a , 36 d) covering filler 37, using a micro etchant (CZ series) made by Mec Co., Ltd. (FIG. 14B).

(9) On both surfaces of the substrate, resin film (50 γ) for interlayer resin insulation layer (brand name ABF-45SH, made by Ajinomoto Fine-Techno Co., Inc.) with a slightly larger size than the substrate was placed and preliminarily pressed under the conditions of pressure 0.45 MPa, temperature 80° C. and pressing time 10 seconds, and cut to size. Then, by laminating the film using vacuum laminator equipment under the following conditions, resin insulation layers 50 were formed (FIG. 14C). Namely, the resin film for interlayer resin insulation layer on the substrate was given a final pressing under the conditions of vacuum degree 67 Pa, pressure 0.47 MPa, temperature 85° C. and pressing time 60 seconds, and then thermoset at 170° C. for 40 minutes.

(10) Next, using a CO₂ gas laser with a wave length of 10.4 μm , via hole openings 51 were formed in resin insulation layers 50 under the conditions of beam diameter 4.0 mm, top-hat mode, pulse width 3-30 $\mu\text{sec.}$, mask through-hole diameter 1.0-5.0 mm and number of shots 1-3 (FIG. 14D). The above laser conditions were adjusted so that the bottom diameter of via holes in resin insulation layers 50 would become $\Phi 60 \mu\text{m}$. As a result, the bottom diameter of the via holes formed on plated-cover layers (36 a , 36 d) was made $\Phi 60 \mu\text{m}$.

(11) The substrate with via hole opening 51 was immersed for 10 minutes in an 80° C. solution containing permanganic acid 60 g/l, and epoxy-resin particles residing on the surfaces of resin insulation layers 50 were dissolved and removed. Accordingly, roughened surfaces (50 α) were formed on the surfaces of resin insulation layers 50 including the inner walls of via hole opening 51 (FIG. 15A).

(12) Next, after the above treatments, the substrate was immersed in a neutralizer (made by Shipley Company, LLC) and was washed with water. Furthermore, by applying palladium catalyst on the roughened surfaces (roughened depth 3 μm) of the substrate, catalyst nuclei were adhered to the surfaces of the resin insulation layers and the inner-wall surfaces of the filled-via openings. Namely, the substrate was immersed in a catalytic solution containing palladium chloride (PbC₁₂) and stannous chloride (SnC₁₂), and the catalyst was adhered to the surfaces through deposition of palladium metal.

(13) Next, the substrate with applied catalyst was immersed in an electroless copper plating solution (Thru-Cup PEA) made by C. Uyemura & Co., Ltd. to form electroless copper-plated film with a thickness of 0.3-3.0 μm on the entire roughened surfaces. Accordingly, the substrate was obtained where electroless copper-plated film 52 was formed on the surfaces of resin insulation layers 50 including the inner walls of via-hole opening 51 (FIG. 15B).

[Electroless Plating Conditions]

Solution Temperature at 34° C. for 45 Minutes

(14) On the substrate having electroless copper-plated film 52, commercially available photosensitive dry film was laminated, and a mask was placed on the film, which was then exposed to light at 110 mJ/cm² and developed with a 0.8% sodium carbonate solution. Accordingly, plating resists 54 with a thickness of 25 μm were formed (FIG. 15C).

(15) Then, after substrate 30 was cleansed with 50° C. water to degrease it and washed with 25° C. water, the substrate was further cleansed with sulfuric acid. Then, electrolytic plating was performed under the following conditions to form electrolytic plated-metal film 56 (FIG. 16A).

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[Electrolytic Plating Solution]

sulfuric acid	2.24 mol/l
copper sulfate	0.26 mol/l
additive	19.5 ml/l
leveling agent	50 mg/l
polishing agent	50 mg/l

[Electrolytic Plating Conditions]

current density	1 A/dm ²
time	70 minutes
temperature	22 ± 2° C.

(16) Furthermore, after plating resists **54** were removed using a 5% KOH solution, electroless plated-metal film under the plating resists was removed by etching using a mixed solution of sulfuric acid and hydrogen peroxide. Accordingly, independent conductive circuits **58** and filled vias **60** were formed (FIG. **16B**).

(17) Next, by conducting the same treatment as in above step (4), roughened surfaces (**58α**) were formed on the surfaces of conductive circuits **58** and filled vias **60**. The thickness of upper-layer conductive circuits **58** was 15 μm (FIG. **16C**). However, the thickness of upper-layer conductive circuits may be set anywhere between 5 and 25 μm.

(18) By repeating steps (9)-(15), conductive circuits **158** and filled vias **160** made of electroless plated-metal film **152** and electrolytic plated-metal film **156** were formed in areas of upper-layer resin insulation layers **150** where plating resist **154** was not formed (FIG. **16D**).

(19) Second plating resist **155** for forming pads was formed on copper-plated film **156** which will later become wiring patterns (FIG. **17A**).

(20) The substrate was immersed in an electrolytic plating solution to form electrolytic copper-plated film **159** with a thickness of 2-10 μm on copper-plated film **156** in areas where second plating resist **155** was not formed (FIG. **17B**).

(21) Plating resists **154** and second plating resists **155** were removed, and pads **161** made from copper-plated film **159** were formed on wiring **158**, which was made from copper-plated film **156**. Then, metal film **152** under plating resists **154** was removed by etching (FIG. **17C**).

(22) Next, on both surfaces of a multilayer wiring substrate, a commercially available solder-resist composition (**70**) was applied to be 25-35 μm thick, which was then dried at 70° C. for 20 minutes and at 70° C. for 30 minutes. Then, a 5-mm thick photomask with a pattern of solder-resist openings was adhered to solder resist layers **70**, which were then exposed to ultraviolet rays at 1000 mJ/cm² and developed using a DMTG solution. Accordingly, openings **71** were formed with a diameter of 200 μm (FIG. **18A**). In addition, heat treatments were conducted at 80° C. for an hour, 100° C. for an hour, 120° C. for an hour and 150° C. for three hours to cure the solder resist layers. Accordingly, solder-resist pattern layers having openings are formed with a thickness of 20-30 μm.

(23) Next, regarding the substrate with solder-resist layers **70**, resist film was formed on the upper-side resist layer, and nickel-plated layer **72** and gold-plated layer **74** were formed in opening portions **71** of the lower-side solder-resist layer. Here, the substrate was immersed for 20 minutes in an electroless nickel plating solution of pH=4.5 containing nickel chloride (2.3×10⁻¹ mol/l), sodium hypophosphite (2.8×10⁻¹

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mol/l) and sodium citrate (1.6×10⁻¹ mol/l); and a 0.5 nm-thick nickel-plated layer **72** was formed in opening portions **71**. Furthermore, the substrate was immersed for 7.5 minutes at 80° C. in an electroless gold plating solution containing gold potassium cyanide (7.6×10⁻³ mol/l), ammonium chloride (1.9×10⁻¹ mol/l), sodium citrate (1.2×10⁻¹ mol/l) and sodium hypophosphite (1.7×10⁻¹ mol/l). Accordingly, a 0.03 μm-thick gold-plated layer **74** was formed on nickel-plated layer **72** (FIG. **18B**). Other than a nickel-gold layer, a single layer of tin or a noble metal layer (gold, silver, palladium, platinum, lead, zinc or the like) may be formed.

(24) After that, Sn/Ag solder paste (**76α**) was printed to be (3+1.5) μm thick in openings **71** of the upper-side solder-resist layer; and tin-antimony solder paste **77** was printed in openings **71** of the lower-side solder-resist layer (FIG. **18C**).

(25) After reflowing at 200° C., solder bumps **76** were formed on upper-side pads **161** and solder bumps **78** were formed in lower-side openings **71**. Accordingly, a multilayer printed wiring board was manufactured (FIG. **19**).

In the following, mounting an IC chip on multilayer printed wiring board **10** and further mounting the wiring board on a daughterboard are described.

Gold-stud bumps **91** of IC chip **90** to be mounted on the multilayer printed wiring board are aligned to face pads **161** of multilayer printed wiring board **10**. Then, IC chip **90** is pressed against printed wiring board **10** to connect gold-stud bumps **91** and solder bumps **76** of pads **161**, and IC chip **90** is mounted on multilayer printed wiring board **10**. Then, multilayer printed wiring board **10** is mounted on daughterboard **94** by means of solder bumps **78** (FIG. **20**).

Obviously, numerous modifications and variations of the present invention are possible in light of the above teachings. It is therefore to be understood that within the scope of the appended claims, the invention may be practiced otherwise than as specifically described herein.

What is claimed is:

1. A method for manufacturing a printed wiring board, comprising:

- preparing an insulative board;
- forming a metal film on a surface of the insulative board;
- forming a plating resist on the metal film;
- forming a plated-metal film on the metal film exposed from the plating resist;
- covering a portion of the plated-metal film with an etching resist;
- etching to reduce a thickness of the plated-metal film exposed from the etching resist;
- removing the etching resist;
- removing the plating resist;
- forming a wiring having a pad and a conductive circuit thinner than the pad by removing the metal film exposed through the removing of the plating resist;
- forming a solder-resist layer on the surface of the insulative board and the wiring;
- forming in the solder-resist layer an opening that exposes the pad and a portion of the conductive circuit contiguous to the pad;
- forming a solder film on the pad and the portion of the conductive circuit exposed through the opening; and
- forming a solder bump on the pad by agglomerating solder on the pad through a reflow,

wherein the pad has a pad thickness which is greater than a circuit thickness of the conductive circuit, the solder bump on the pad has a first bump thickness which is greater than a second bump thickness of the solder bump on the conductive circuit, and the pad thickness, the circuit thickness, the first bump thickness, and the sec-

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ond bump thickness are in a direction orthogonally to the surface of the insulative board.

2. The method for manufacturing the printed wiring board according to claim 1, wherein the pad is formed of the metal film and the plated-metal film formed on the metal film.

3. The method for manufacturing the printed wiring board according to claim 2, wherein the plated-metal film that forms the pad is the plated-metal film exposed by removing the etching resist.

4. The method for manufacturing the printed wiring board according to claim 2, wherein the conductive circuit is formed of the metal film and the plated-metal film on the metal film, and a thickness of the plated-metal film that forms the conductive circuit is less than a thickness of the plated-metal film that forms the pad.

5. The method for manufacturing the printed wiring board according to claim 4, wherein the thickness is made thinner by reducing the thickness of the plated-metal film.

6. The method for manufacturing the printed wiring board according to claim 1, wherein the conductive circuit is formed of a portion of the metal film.

7. The method for manufacturing the printed wiring board according to claim 1, wherein the pad thickness is 2-10 μm greater than the circuit thickness.

8. The method for manufacturing the printed wiring board according to claim 1, wherein the pad has a pad width which is substantially the same as a circuit width of the conductive circuit, wherein the pad width and the circuit width are in a direction parallel to the surface of the insulative board.

9. The method for manufacturing the printed wiring board according to claim 1, wherein the first bump thickness and the second bump thickness have a ratio which is in a range of 1.1-15.

10. The method for manufacturing the printed wiring board according to claim 1, further comprising forming the metal layer comprising at least one metal selected from the group consisting of Ni, Pd, Pt, Pb, Ag, Sn and Zn on the pad and the conductive circuit exposed through the opening.

11. A method for manufacturing a printed wiring board, comprising:

preparing an insulative board;

forming a metal film on a surface of the insulative board; covering a portion of the metal film with a first plating resist;

forming a first plated-metal film on the metal film exposed from the first plating resist;

covering a portion of the first plated-metal film with a second plating resist;

forming a second plated-metal film on the first plated-metal film exposed from the second plating resist;

removing the first and second plating resists;

forming a wiring having a pad and a conductive circuit thinner than the pad by removing the metal film exposed by the first and second plated-metal films;

forming a solder-resist layer on the surface of the insulative board and the wiring;

forming in the solder-resist layer an opening that exposes the pad and a portion of the conductive circuit contiguous to the pad;

forming solder film on the pad and the portion of the conductive circuit exposed through the opening; and

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forming a solder bump on the pad by agglomerating solder on the pad through a reflow,

wherein the pad has a pad thickness which is greater than a circuit thickness of the conductive circuit, the solder bump on the pad has a first bump thickness which is greater than a second bump thickness of the solder bump on the conductive circuit, and the pad thickness, the circuit thickness, the first bump thickness, and the second bump thickness are in a direction orthogonally to the surface of the insulative board.

12. The method for manufacturing the printed wiring board according to claim 11, wherein the pad thickness is 2-10 μm greater than the circuit thickness.

13. The method for manufacturing the printed wiring board according to claim 11, wherein the pad has a pad width which is substantially the same as a circuit width of the conductive circuit, wherein the pad width and the circuit width are in a direction parallel to the surface of the insulative board.

14. The method for manufacturing the printed wiring board according to claim 11, wherein the first bump thickness and the second bump thickness have a ratio which is in a range of 1.1-15.

15. The method for manufacturing the printed wiring board according to claim 11, further comprising forming the metal layer comprising at least one metal selected from the group consisting of Ni, Pd, Pt, Pb, Ag, Sn and Zn on the pad and the conductive circuit exposed through the opening.

16. A printed wiring board comprising:

an insulative board;

a wiring formed on a surface of the insulative board and having a pad configured to mount an electronic component and a conductive circuit contiguous to the pad; and a solder bump formed on the pad and a portion of the conductive circuit contiguous to the pad,

wherein the pad has a pad thickness which is greater than a circuit thickness of the conductive circuit, and the solder bump on the pad has a first bump thickness which is greater than a second bump thickness of the solder bump on the conductive circuit, and

the pad thickness, the circuit thickness, the first bump thickness, and the second bump thickness are in a direction orthogonally to the surface of the insulative board.

17. The printed wiring board according to claim 16, wherein the pad has a pad width which is substantially the same as a circuit width of the conductive circuit, wherein the pad width and the circuit width are in a direction parallel to the surface of the insulative board.

18. The printed wiring board according to claim 16, wherein the pad thickness is 2-10 μm greater than the circuit thickness.

19. The printed wiring board according to claim 16, wherein the first bump thickness and the second bump thickness have a ratio which is in a range of 1.1-15.

20. The printed wiring board according to claim 16, further comprising a solder-resist layer formed on the surface of the insulative board and a surface of the wiring, wherein the pad thickness is less than a thickness of the solder-resist layer and the pad thickness is greater than the circuit thickness.

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